Scientific ---

Scientific and Technical Information Center

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Requester's Full Name:	214 7). CEL	Examiner #:	76060	Date:
Art Unit: 1752	Phone Numbe	er 30 2-13:	33 Serial N	umber:	0/530,349
Mail Box and Bldg/Room	Location: 9	C/5 Re CRem.)	sults Format Pro	eferred (circle)	Date:
If more than one search	is submitted,	please priorit	ize searches i	n order of n	eed.
Please provide a detailed stater Include the elected species or s utility of the invention. Define known. Please attach a copy of	tructures, keyword any terms that ma	ls, synonyms, acr	onyms, and registry meaning. Give exa	numbers, and	combine with the concept or
Title of Invention:	P12	. see	Bib.		
Inventors (please provide ful	names):				
Earliest Priority Filing Da	te:			1 to to the collection	
For Sequence Searches Only I appropriate serial number.	Please include all pe	rtinent information	ı (parent, child, divis	ional, or issued p	patent numbers) along with the

Please Search

for a triazme trione compound having a substituent of formula (2) or (3)

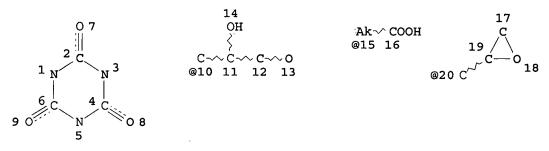
as substituent on nitrogen atom

(Ale c1. #1)

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L4198713 SEA FILE=REGISTRY ABB=ON PLU=ON 46.492/RID

L11 STR



G1 21

VAR G1=10/15/20 NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

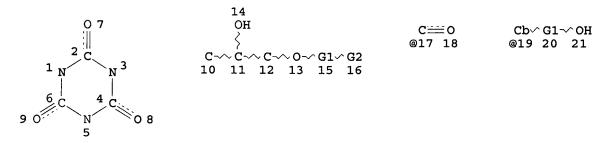
NUMBER OF NODES IS 21

STEREO ATTRIBUTES: NONE

L13

1699 SEA FILE=REGISTRY SUB=L4 SSS FUL L11

L16



REP G1=(0-1) 17 VAR G2=N/19 NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS

STEREO ATTRIBUTES: NONE

L18 19 SEA FILE=REGISTRY SUB=L13 SSS FUL L16 L44

12 SEA FILE=HCAPLUS ABB=ON PLU=ON L18

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L44 ANSWER 1 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

USHA SHRESTHA EIC 1700 REM 4B31

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2006:541892 HCAPLUS
ACCESSION NUMBER:
                           145:53315
DOCUMENT NUMBER:
TITLE:
                           Method for forming photoresist pattern using
                           double layer antireflection film
INVENTOR(S):
                           Hatanaka, Tadashi
PATENT ASSIGNEE(S):
                           Nissan Chemical Industries, Ltd., Japan
SOURCE:
                           PCT Int. Appl., 44 pp.
                           CODEN: PIXXD2
                           Patent
DOCUMENT TYPE:
LANGUAGE:
                           Japanese
FAMILY ACC. NUM. COUNT:
PATENT INFORMATION:
      PATENT NO.
                           KIND
                                   DATE
                                                APPLICATION NO.
                                                                        DATE
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      WO 2006059452
                            A1
                                   20060608
                                                WO 2005-JP201/2
                                                                        20051101
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              TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW
          RW: AT, BE, BG, CH, CY, CZ, DE, DK, EE, $\overline{\psi}s$, FI, FR, GB, GR, HU,
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PRIORITY APPLN. INFO.:
                                                JF 2004-351351
                                                                     A 20041203
ED
      Entered STN: 09 Jun 2006
AB
     Disclosed is a method for forming a pattern, wherein both photoresist
      and antireflection film have a rectangular shape, in a lithog. process
      of semiconductor device production by using an antireflection film which is developable by a photoresist developer liquid Specifically disclosed
      is a method for forming a photores st pattern comprising a step for
      forming a first antireflection film which is soluble in a photoresist
      developer liquid; a step for forming, on the first antireflection film,
      a second antireflection film which is soluble in the photoresist
      developer liquid and whose dissolving rate in the photoresist developer
      liquid is lower than that of the first antireflection film; a step for
      forming a photoresist on the second antireflection film; a step for
      exposing a semiconductor substrate which is covered with the first
      antireflection film, the segond antireflection film and the
     photoresist; and a step for developing by using the photoresist
     developer liquid
TΤ
      681258-78-6P
         (antireflection film forming composition; method for forming photoresist
         pattern using double layer antireflection film in semiconductor
         device fabrication process)
      681258-78-6 HCAPLUS
RN
CN
      2-Naphthalenecarboxylic acid, 3,7-dihydroxy-, 2,2',2''-[(2,4,6-trioxo-
      1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tris(2-hydroxy-3,1-propanediyl)]
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ester (CA INDEX NAME)

PAGE 1-B

OH

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 38, 73, 76

6

IT 681258-78-6P 889868-86-4P

(antireflection film forming composition; method for forming photoresist pattern using double layer antireflection film in semiconductor device fabrication process)

REFERENCE COUNT:

THERE ARE 6 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L44 ANSWER 2 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

2005:1241189 HCAPLUS

DOCUMENT NUMBER:

143:485834

TITLE:

Antireflective film-forming composition containing

vinyl ether compound for photoresist pattern

INVENTOR(S):

Hatanaka, Tadashi; Kimura, Shigeo; Enomoto,

Tomoyuki

PATENT ASSIGNEE(S):

Nissan Chemical Industries, Ltd., Japan

SOURCE:

PCT Int. Appl., 56 pp.

DOCUMENT TYPE:

CODEN: PIXXD2

LANGUAGE:

Patent

EAMILY ACC NUM

Japanese

FAMILY ACC. NUM. COUNT:

': 1

PATENT INFORMATION:

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PATENT NO.
                          KIND
                                  DATE
                                               APPLICATION NO.
                                                                       DATE
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     WO 2005111724
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     EP 1757987
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                                                                       20050511
PRIORITY APPLN. INFO.:
                                               JP 2004-144625
                                                                       20040514
                                                                       20041207
                                               JP 2004-353627
                                               WO 2005-JP8617
                                                                       20050511
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ED Entered STN: 24 Nov 2005

AB Disclosed is an antireflective film-forming composition for forming an antireflective film which is used in the lithog. process during semiconductor device production and can be developed with an alkaline developer for photoresists. Also disclosed is a method for forming a photoresist pattern using such an antireflective film-forming composition. The antireflective film-forming composition contains a compound having at least two vinyl ether groups, an alkali-soluble compound having at least two phenolic hydroxy groups or carboxyl groups, a photoacid generator and a solvent.

IT 869792-92-7P

CN

(antireflective film-forming composition containing vinyl ether compound for photoresist pattern)

RN 869792-92-7 HCAPLUS

1-Naphthalenecarboxylic acid, 2,6-dihydroxy-, 3-[3,5-bis[3-[[(3,7-dihydroxy-2-naphthalenyl)carbonyl]oxy]-2-hydroxypropyl]tetrahydro-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2-hydroxypropyl ester (9CI) (CAINDEX NAME)

HO

OH

OH

OH

HO

$$C-O-CH_2-CH-CH_2-N$$
 OH
 OH

PAGE 1-B

IC ICM G03F007-11

ICS G03F007-20; G03F007-38; H01L021-027

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 76
IT 869792-92-7P 869792-93-8P 869792-94-9P 869792-95-0P

869792-96-1P
(antireflective film-forming composition containing vinyl ether compound for photoresist pattern)

REFERENCE COUNT:

THERE ARE 13 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE

RE FORMAT

L44 ANSWER 3 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 2005:219904 HCAPLUS

DOCUMENT NUMBER: 142:306447

TITLE: Polyamic acid-containing composition for forming

antireflective film

INVENTOR(S): Hatanaka, Tadashi; Enomoto, Tomoyuki; Kimura,

Shigeo

PATENT ASSIGNEE(S): Nissan Chemical Industries, Ltd., Japan

SOURCE: PCT Int. Appl., 52 pp.

CODEN: PIXXD2

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PA'	TENT 1	NO.			KIN	D	DATE	/		APPL	ICAT:	ION 1	NO.		D	ATE
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PRIORIT	Y APP	LN.	INFO	. :						JP 2				i	-	0030828
										WO 2	004-0	JP12:	389	Ţ	W 20	0040827

ED Entered STN: 11 Mar 2005

Disclosed is a composition for forming an antireflective film which is used AB in the lithog. process in semiconductor device production and can be developed with an alkaline developing solution for photoresists. Also disclosed is a method for forming a photoresist pattern by using such a composition for forming an antireflective film. The composition for forming an antireflective film contains a polyamic acid produced from a tetracarboxylic acid dianhydride compound and a diamine compound having at least one carboxyl group, a compound having at least two epoxy groups and a solvent.

IT 681258-78-6P

(preparation of light-absorbing compound for antireflective film)

RN 681258-78-6 HCAPLUS

2-Naphthalenecarboxylic acid, 3,7-dihydroxy-, 2,2',2''-[(2,4,6-trioxo-CN 1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tris(2-hydroxy-3,1-propanediyl)] ester (CA INDEX NAME)

PAGE 1-B

OH

IC ICM G03F007-11 ICS H01L021-027

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 41, 76

IT 681258-78-6P

(preparation of light-absorbing compound for antireflective film) REFERENCE COUNT: 15 THERE ARE 15 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE

RE FORMAT

L44 ANSWER 4 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

2004:333991 HCAPLUS

DOCUMENT NUMBER:

140:359011

TITLE:

Bottom anti-reflective coatings derived from small

core molecules with multiple epoxy moieties

INVENTOR(S): Neef, Charles J.; Bhave, Mandar; Fowler, Michelle; Windsor, Michelle

PATENT ASSIGNEE(S): Brewer Science, Inc., USA

SOURCE:

PCT Int. Appl., 31 pp.

CODEN: PIXXD2

DOCUMENT TYPE:

Patent

LANGUAGE:

1

FAMILY ACC. NUM. COUNT:

English

PATENT INFORMATION:

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APPLICATION NO.
          PATENT NO.
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          WO 2004034435
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                                                               20040610
                                                                                       US 2003-679521
                                                                                                                                     20031(06)
         AU 2003282554
                                                   Α1
                                                               20040504
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                                                                                                                                     20031007
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PRIORITY APPLN. INFO.:
                                                                                       US 2002-417214P
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                                                                                       US 2003-679521
                                                                                                                               A 20031006
                                                                                       WO 2003-US32091
                                                                                                                               W 20031007
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OTHER SOURCE(S): MARPAT 140:359011

ED Entered STN: 23 Apr 2004

Novel anti-reflective coatings comprising small mols. (e.g., less than AΒ about 5000 g/mol) in lieu of high mol. weight polymers and methods of using those coatings are provided. In one embodiment, aromatic carboxylic acids are used as the chromophores, and the resulting compds. are blended with a crosslinking agent and an acid. Anti-reflective coating films prepared according to the invention exhibit improved properties compared to high mol. weight polymeric anti-reflective coating films. The small mol. anti-reflective coatings have high etch rates and good via fill properties. Photolithog. processes carried out with the inventive material result in freestanding, 110-nm profiles. Thus, heating tris(2,3epoxypropyl)isocyanurate 17.84 with 4-hydroxybenzoic acid 24.86, benzyltriethylammonium chloride 1.03 and propylene glycol Pr ether 384.3 g at 120° for 16 h under N and mixing the resulting mother liquor 20 with Powderlink 1174 (crosslinking agent) 0.50, p-toluenesulfonic acid 0.06 g, propylene glycol Pr ether 10.84 and Et lactate 28.84 g gave a coating which was coated on a wafer, baked at 205° for seconds, sprayed with Et acetate or propylene glycol monomethyl ether acetate and spin dried to give a coat film with good claimed properties.

IT 681258-74-2P

(bottom anti-reflective coatings derived from small core mols. with multiple epoxy moieties)

RN 681258-74-2 HCAPLUS

CN Benzoic acid, 4-hydroxy-, (2,4,6-trioxo-1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tris(2-hydroxy-3,1-propanediyl) ester (9CI) (CA INDEX NAME)

PAGE 1-B

__ OH

IT 681258-75-3P 681258-78-6P 681258-79-7P

(bottom anti-reflective coatings derived from small core mols. with multiple epoxy moieties)

RN 681258-75-3 HCAPLUS

CN Benzoic acid, 4-hydroxy-, (2,4,6-trioxo-1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tris(2-hydroxy-3,1-propanediyl) ester, polymer with tetrahydro-1,3,4,6-tetrakis(methoxymethyl)imidazo[4,5-d]imidazole-2,5(1H,3H)-dione (9CI) (CA INDEX NAME)

CM 1

CRN 681258-74-2 CMF C33 H33 N3 O15



United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1430 Alexandria, Vigania 22)13-1450 www.uspto.gov

CONFIRMATION NO. 7775



Bib Data Sheet

FILING OR 371(c) ATTORNEY DOCKET DATE **GROUP ART UNIT CLASS** NO. SERIAL NUMBER 04/06/2005 430 1752 10/530,349 123418 RULE APPLICANTS Takahiro Kishioka, Nei-gun, JAPAN; Ken-ichi Mizusawa, Chiyoda-ku, JAPAN; Tomovuki Enomoto, Nei-gun, JAPAN; Rikimaru Sakamoto, Nei-gun, JAPAN; Keisuke Nakayama, Nei-gun, JAPAN; Yasuo Kawamura, Funabashi-shi, JAPAN; This application is a 371 of PCT/JP03/12875 10/08/2003 JAPAN 2002-295777 10/09/2002 JAPAN 2003-126886 05/02/2003 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/18/2006 ves \square no Foreign Priority claimed INDEPENDENT SHEETS TOTAL STATE OR 35 USC 119 (a-d) conditions met yes no Met after Allowance **CLAIMS** DRAWING **CLAIMS** COUNTRY 19 **JAPAN** Verified and Acknowledged Examiner's Signature **ADDRESS** 25944 TITLE Composition for forming anti-reflective coating for use in lithography All Fees 1.16 Fees (Filing) FEES: Authority has been given in Paper 1.17 Fees (Processing Ext. of time) **FILING FEE** to charge/credit DEPOSIT ACCOUNT for following: RECEIVED 🚽 1.18 Fees (Issue) 1030 Other Credit

PAGE 1-B

__ OH

CM 2

CRN 17464-88-9 CMF C12 H22 N4 O6

RN 681258-78-6 HCAPLUS

CN 2-Naphthalenecarboxylic acid, 3,7-dihydroxy-, 2,2',2''-[(2,4,6-trioxo-1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tris(2-hydroxy-3,1-propanediyl)] ester (CA INDEX NAME)

PAGE 1-B

RN 681258-79-7 HCAPLUS

CN 2-Naphthalenecarboxylic acid, 3,7-dihydroxy-, (2,4,6-trioxo-1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tris(2-hydroxy-3,1-propanediyl) ester, polymer with tetrahydro-1,3,4,6-tetrakis(methoxymethyl)imidazo[4,5-d]imidazole-2,5(1H,3H)-dione (9CI) (CA INDEX NAME)

CM 1

CRN 681258-78-6 CMF C45 H39 N3 O18

CM 2

CRN 17464-88-9 CMF C12 H22 N4 O6

IC ICM H01L

CC 42-9 (Coatings, Inks, and Related Products)

Section cross-reference(s): 74, 76

IT 681258-74-2P 681258-76-4P 681258-80-0P 681437-59-2P (bottom anti-reflective coatings derived from small core mols. with multiple epoxy moieties)

IT 681258-75-3P 681258-77-5P 681258-78-6P 681258-79-7P 681258-81-1P 681437-62-7P

(bottom anti-reflective coatings derived from small core mols. with multiple epoxy moieties)

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L44 ANSWER 5 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN
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ACCESSION NUMBER:

2004:120819 HCAPLUS

DOCUMENT NUMBER:

140:165096

TITLE:

Fluorinated urethane compounds and compositions

containing the same

INVENTOR (S):

Yamamoto, Ikuo; Kusumi, Kayo; Yoshioka, Takuya;

Yamaguchi, Fumihiko

PATENT ASSIGNEE(S):

Daikin Industries, Ltd., Japan

SOURCE:

PCT Int. Appl., 25 pp.

CODEN: PIXXD2

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

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		SY,	TJ,	TM,	TN,	TR,	TT,	TZ,	UA,	UG,	US,	UZ,	VC,	VN,	YU,	ZA,
		ZM,							·	·	•	-	•	•	·	•
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		BY,	KG,	ΚZ,	MD,	RU,	ТJ,	TM,	AT,	BE,	BG,	CH,	CY,	CZ,	DE,	DK,
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AU	2003	2523	90		A1		2004	0223		AU 2	003-	2523	90		2	0030805
EP	1548	001			A1		2005	0629		EP 2	003-	7667	31		2	0030805
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									,	WO 2	003-	JP99	03	1	W 2	0030805

ED Entered STN: 13 Feb 2004 AB

Fluorinated urethane compds. [RfA1(X1(OH))(Y1)a-OC(:O)NH]mI[NHC(:O)OY2]n[NHC(:O)O((ClCH2)X2O)bR1]k can impart high water- and oil-repellency, wherein I = a group derived from a polyisocyanate compound by removing the isocyanato groups; Rf = C2-21 perfluoroalkyl; A1 = a direct bond or C1-21 divalent organic group; X1, X2 = C2-5 trivalent, linear or branched aliphatic group; Y1 = a divalent organic group containing C0-5, N0-2, and ≥1 hydrogen atom (≥1 carbon atom or ≥1 nitrogen atom must be present); Y2 = a monovalent organic group which may have a hydroxyl group; and R1 = H or C1-10 alkyl. Thus, 20.1 g 3-perfluorooctyl-1,2-propanediol obtained from 3-perfluorooctyl-1,2-epoxypropane and 7.79 g Sumidur N 3300 were reacted to give 25.3 g hydroxy-containing perfluotooctylpropyl substituted hexamethylene diisocyanate isocyanurate, 5 g of which was emulsified in the presence of polyethylene glycol alkyl ether and sodium α -olefinsulfonate, applied on a carpet and heat-cured to give a

test piece showing good water and oil repellency and anticontamination.

IT 653600-17-0P

(preparation of fluorinated urethane compds. for compns.)

RN 653600-17-0 HCAPLUS

CN Carbamic acid, [(2,4,6-trioxo-1,3,5-triazine-1,3,5(2H,4H,6H)-triy1)tri-6,1-hexanediyl]tris-, tris(4,4,5,5,6,6,7,7,8,8,9,9,10,10,11,11,11-heptadecafluoro-2-hydroxyundecyl) ester (9CI) (CA INDEX NAME)

IT 653600-18-1

(preparation of fluorinated urethane compds. for compns.)

RN 653600-18-1 HCAPLUS

CN Carbamic acid, [(2,4,6-trioxo-1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tri-6,1-hexanediyl]tris-, tris(4,4,5,5,6,6,7,7,8,8,9,9,10,10,11,11,11-heptadecafluoro-2-hydroxyundecyl) ester, homopolymer (9CI) (CA INDEX NAME)

CM 1

CRN 653600-17-0

CMF C57 H57 F51 N6 O12

```
OH
- O- CH<sub>2</sub>- CH- CH<sub>2</sub>- (CF<sub>2</sub>)<sub>7</sub>- CF<sub>3</sub>
IC
     ICM C07C275-62
     ICS C09K003-00; C09K003-18; C07D251-34; D06M015-576
CC
     38-3 (Plastics Fabrication and Uses)
     Section cross-reference(s): 40
IT
                   653600-19-2P
     653600-17-0P
         (preparation of fluorinated urethane compds. for compns.)
IT
     653600-18-1
         (preparation of fluorinated urethane compds. for compns.)
     ANSWER 6 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN
                          2001:874760 HCAPLUS
ACCESSION NUMBER:
DOCUMENT NUMBER:
                          136:342504
TITLE:
                          Synthesis of the ultraviolet absorber UV-1009
AUTHOR(S):
                          Yi, Bing; Lin, Yuan-bin; Guo, Xian-luo
CORPORATE SOURCE:
                          Dep. Chem., Hunan Eng. Inst., Xiangtan, 411101,
                          Peop. Rep. China
SOURCE:
                          Jingxi Huagong Zhongjianti (2001), 31(4), 9-10
                          CODEN: JHZIAR; ISSN: 1009-9212
PUBLISHER:
                          Jingxi Huagong Zhongjianti Zazhishe
DOCUMENT TYPE:
                          Journal
LANGUAGE:
                          Chinese
ED
     Entered STN: 05 Dec 2001
AB
     A new high relative mol. mass UV absorber UV-1009 was prepared by using
     urea as starting material, which is converted into isocyanuric acid
     via pyrosis condensation. The latter reacts with epichlorohydrin,
     octadecanoic acid and 2,4-dihydroxybenzophenone in turn. The total
     yield of product is over 76%.
IT
     84139-15-1P, UV 1009
        (UV 1009; synthesis of UV absorber UV 1009
     84139-15-1 HCAPLUS
RN
CN
     Octadecanoic acid, 3-[3,5-bis[3-(4-benzoyl/3-hydroxyphenoxy)-2-
     hydroxypropyl]tetrahydro-2,4,6-trioxo-1,3/5-triazin-1(2H)-yl]-2-
     hydroxypropyl ester (9CI) (CA INDEX NAME)
                                                             PAGE 1-A
                                                              OH
                       OH
                                               OH
                                          СН2-СН-
                                CH-CH2
                                OH
```

0 || __ C— Ph

CC 45-4 (Industrial Organic Chemicals, Leather, Fats, and Waxes)

Section cross-reference(s): 37

IT 84139-15-1P, UV 1009

(UV 1009; synthesis of UV absorber UV 1009)

L44 ANSWER 7 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1999:6

1999:65053.0 HCAPLUS

DOCUMENT NUMBER:

131:279194

TITLE:

Isocyanurate wide range UV-absorber for thin film

INVENTOR(S):

Samukawa, Seiji

PATENT ASSIGNEE(S): SOURCE:

Kyodo Chemical Co., Ltd., Japan Jpn. Kokai Tokkyo Koho, 5 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 11279523	Α	19991012	JP 1998-121594	19980326
PRIORITY APPLN. INFO.:			JP 1998-121594	19980326

OTHER SOURCE(S):

MARPAT 131:279194

ED Entered STN: 13 Oct 1999

GI

- AB The isocyanurate wide range UV-absorber for thin film has structure I (R1-3 = aromatic substituent). The UV absorber shows the excellent co-solubility with a polymer to form a thin film.
- IT 245504-65-8P 245512-31-6P 245512-32-7P

(isocyanurate wide range UV-absorber for thin film)

I

- RN 245504-65-8 HCAPLUS
- CN Benzoic acid, 4-(dimethylamino)-, 3-[3-[4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]tetrahydro-5-[2-hydroxy-3-[[3-(4-methoxyphenyl)-1-oxo-2-propenyl]oxy]propyl]-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2-hydroxypropyl ester (9CI) (CA INDEX NAME)

RN 245512-31-6 HCAPLUS

CN 2-Propenoic acid, 3-(4-methoxyphenyl)-, 3-[3-[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]-5-[3-[4-(5-chloro-2H-benzotriazol-2-yl)-3-hydroxyphenoxy]-2-hydroxypropyl]tetrahydro-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2-hydroxypropyl ester (9CI) (CA INDEX NAME)

PAGE 1-A

RN 245512-32-7 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]-3-[3-[4-(5-chloro-2H-benzotriazol-2-yl)-3-hydroxyphenoxy]-2-hydroxypropyl]-5-[2-hydroxy-3-[(2,2,6,6-tetramethyl-4-piperidinyl)amino]propyl]- (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

PAGE 2-A

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IC ICM C09K003-00

ICS C07D251-34; C07D401-14; C07D487-04; C07D519-00

CC 74-1 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 42

IT 245504-65-8P 245512-31-6P 245512-32-7P

(isocyanurate wide range UV-absorber for thin film)

L44 ANSWER 8 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1995:589843 HCAPLUS

DOCUMENT NUMBER: 123:171315

TITLE: Synthesis of high molecular weight ultraviolet

Absorbent UV-1009

AUTHOR(S): Zhu, Xu'en; Yu, Hong

CORPORATE SOURCE: Department Chemical Engineering, Northwest

University, Xi'an, 710069, Peop. Rep. China

SOURCE: Xibei Daxue Xuebao, Ziran Kexueban (1995), 25(1),

75-7

CODEN: HPHPAQ; ISSN: 1000-274X

PUBLISHER: Xibei Daxue Xuebao Bianjibu

DOCUMENT TYPE: Journal LANGUAGE: Chinese

ED Entered STN: 06 Jun 1995

AB In the presence of catalyst, high mol. weight UV absorbent UV-1009 was synthesized from tris(2,3-epoxypropyl) isocyanurate, higher fatty acids and 2,4-dihydroxybenzophenone. In the optimum synthetic condition the yield was 89.9%.

IT **84139-15-1P**, UV 1009

(synthesis of high mol. weight UV absorbent UV-1009)

RN 84139-15-1 HCAPLUS

CN Octadecanoic acid, 3-[3,5-bis[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]tetrahydro-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2-hydroxypropyl ester (9CI) (CA INDEX NAME)

PAGE 1-A

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CC 37-6 (Plastics Manufacture and Processing)

IT 131-56-6DP, 2,4-Dihydroxybenzophenone, reaction products with tris(2,3-epoxypropyl) isocyanurate and fatty acid 2451-62-9DP, Tris(2,3-epoxypropyl) isocyanurate, reaction products with 2,4-dihydroxybenzophenone and fatty acid 84139-15-1P, UV

(synthesis of high mol. weight UV absorbent UV-1009)

L44 ANSWER 9 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1995:23295 HCAPLUS

DOCUMENT NUMBER:

122:241304

TITLE:

Properties and application of UV-981 and UV-1009

ultraviolet absorbers

AUTHOR(S):

Zhu, Huen; Yu, Hong; Li, Guozhong

CORPORATE SOURCE:

Dep. Chem. Eng., Northwest Univ., Xi'an, 710069,

Peop. Rep. China

SOURCE:

Xibei Daxue Xuebao, Ziran Kexueban (1994), 24(2),

127-32

CODEN: HPHPAQ; ISSN: 1000-274X

DOCUMENT TYPE:

Journal

LANGUAGE:

Chinese

ED Entered STN: 08 Nov 1994

AB The IR and UV-visible spectra, toxicity, compatibility, heat resistance, water resistance, and aging resistance of benzophenone-type light stabilizers UV-981 and UV-1009 benzophenone-type light stabilizers for polymers are discussed.

IT **84139-15-1**, UV 1009

(properties and application of UV-981 and UV-1009 benzophenone-type light stabilizers for polymers)

RN 84139-15-1 HCAPLUS

CN Octadecanoic acid, 3-[3,5-bis[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]tetrahydro-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2-hydroxypropyl ester (9CI) (CA INDEX NAME)

PAGE 1-A

CC 37-6 (Plastics Manufacture and Processing)

119-61-9D, Benzophenone, derivs. 84139-15-1, UV 1009 ΙT

162261-57-6, UV 981

(properties and application of UV-981 and UV-1009 benzophenone-type light stabilizers for polymers)

L44 ANSWER 10 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1983:35530 HCAPLUS

DOCUMENT NUMBER:

98:35530

TITLE:

Stabilized resin compositions

PATENT ASSIGNEE(S):

Sumitomo Chemical Co., Ltd., Japan

Jpn. Kokai Tokkyo Koho, 5 pp.

SOURCE:

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

	PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
	JP 57117564 JP 63046108	A B	19820722 19880913	JP 1981-3657	19810112
PRI	ORITY APPLN. INFO.:	_		JP 1981-3657	19810112
ED GI	Entered STN: 12 May	y 1984			
С6Н	5CO—ОСН2СНОН	CH2 N	CH ₂ CHOHCH ₂ O	нсн ₂ о ₂ сс ₇ н ₁₅ он — сос ₆ н ₅	I

- triglycidyl isocyanurate [2451-62-9] Reacts with fatty acids, or AB amines and 2,4-dihydroxybenzophenone [131-56-6] to prepare light stabilizers for polypropylene [9003-07-0] and PVC [9002-86-2]. Thus, a film prepared from PVC 100, DOP 48, an epoxidized soybean oil 2, Ca stearate 1, Zn stearate 0.1, and I [84139-19-5] 0.2 part was irradiated 300 h in a carbon arc sunshine weather meter to give a light yellow color, whereas a similar film containing no I gave a blackish-brown color.
- IT 84139-15-1 84139-16-2 84139-17-3 84139-18-4 84139-19-5

(light stabilizers, for PVC and polypropylene)

RN 84139-15-1 HCAPLUS

CN Octadecanoic acid, 3-[3,5-bis[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]tetrahydro-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2-hydroxypropyl ester (9CI) (CA INDEX NAME)

PAGE 1-B

RN 84139-16-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]-5-[3-(dibutylamino)-2-hydroxypropyl]-(9CI) (CA INDEX NAME)

RN 84139-17-3 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]-5-[3-(dioctadecylamino)-2-hydroxypropyl]- (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

RN 84139-18-4 HCAPLUS

CN Octadecanoic acid, [5-[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]dihydro-2,4,6-trioxo-1,3,5-triazine-1,3(2H,4H)-diyl]bis(2-hydroxy-3,1-propanediyl) ester (9CI) (CA INDEX NAME)



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Bib Data Sheet

CONFIRMATION NO. 7775

SERIAL NUMBI 10/530,349	ER	FILING OR 371(c) DATE 04/06/2005 RULE	CLASS 430	GROUP ART UNIT			ATTORNEY DOCKET NO. 123418		
Ken-ichi Miz Tomoyuki Ei Rikimaru Sa Keisuke Nak	usawa, (nomoto, kamoto, kayama, i	ei-gun, JAPAN; Chiyoda-ku, JAPAN; Nei-gun, JAPAN; Nei-gun, JAPAN; Nei-gun, JAPAN; unabashi-shi, JAPAN;							
** FOREIGN APPL JAPAN 2003 JAPAN 2003	tion is a 3 ICATION 2-295777 3-126886	371 of PCT/JP03/12875 S ************************************	SJL)3 6 836	-				
Verified and Acknowledg	ions met	yes no Met after A	Allowance AA ials	STATE OR COUNTRY JAPAN		IEETS AWING 0	CL	TAL , AIMS 19	INDEPENDENT CLAIMS 1
ADDRESS 25944 TITLE Composition for form	ming anti	-reflective coating for us	e in lithog	raphy	-				
RECEIVED	No	uthority has been given to charge/credit l for following:		ACCOUNT		☐ All Fe☐ 1.16 F☐ 1.17 F☐ 1.18 F☐ Other☐ Credit	Fees (F	rocessing	g Ext. of time)

PAGE 1-B

- (CH₂)₁₆- Me

RN 84139-19-5 HCAPLUS

CN Octanoic acid, 3-[3,5-bis[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]tetrahydro-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2-hydroxypropyl ester (9CI) (CA INDEX NAME)

PAGE 1-A

__ C— Ph || |0

IC C08L101-00; C08K005-34

CC 37-6 (Plastics Manufacture and Processing)

IT 84139-15-1 84139-16-2 84139-17-3

84139-18-4 84139-19-5

(light stabilizers, for PVC and polypropylene)

L44 ANSWER 11 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1982:473406 HCAPLUS

DOCUMENT NUMBER:

97:73406

TITLE:

Light stabilizers

PATENT ASSIGNEE(S):

Sumitomo Chemical Co., Ltd., Japan

SOURCE:

Jpn. Kokai Tokkyo Koho, 5 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 57042742	Α	19820310	JP 1980-118183	19800826
JP 62045894	В	19870929		
PRIORITY APPLN. INFO.:			JP 1980-118183	19800826

ED Entered STN: 12 May 1984

GI

AB Compds. I (R = H, R1 = H [82438-55-9]; R = Ac, R1 = H [82447-33-4]; R = H, R1 = p-tert-Bu [82438-56-0]; R = H, R1 = o-Cl [82438-57-1]) are used light stabilizers for polyolefins. Thus, test pieces prepared from Noblen FS 200 [9003-07-0] containing Ca stearate 0.1%, 2,6-di-tert-butyl-4-methylphenol 0.05%, and I (R = H, R1 = H) 0.2% were irradiated for 360 h with a sunshine weatherometer before cracks formed on 1/3 of the surface, compared with 240 h for similar test pieces prepared from polymer not containing I.

IT 82438-55-9 82438-56-0 82438-57-1

Ι

(light stabilizers, for polypropylene)

- RN 82438-55-9 HCAPLUS
- CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris[3-(4-benzoyl-3-hydroxyphenoxy)-2-hydroxypropyl]- (9CI) (CA INDEX NAME)

PAGE 2-B

RN 82438-56-0 HCAPLUS
CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris[3-[4-[4-(1,1-dimethylethyl)benzoyl]-3-hydroxyphenoxy]-2-hydroxypropyl]- (9CI) (CAINDEX NAME)

PAGE 2-B

RN 82438-57-1 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris[3-[4-(2-chlorobenzoyl)-3-hydroxyphenoxy]-2-hydroxypropyl]- (9CI) (CA INDEX

NAME)

PAGE 1-A

PAGE 2-B

IC C08K005-34 ICA C07D251-34 CC 37-6 (Plastics Manufacture and Processing)

IT 82438-55-9 82438-56-0 82438-57-1 82447-33-4

(light stabilizers, for polypropylene)

L44 ANSWER 12 OF 12 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1981:122719 HCAPLUS

DOCUMENT NUMBER: 94:122719

TITLE: Isocyanuric acid derivatives as constructional

glue adhesives

INVENTOR(S): Eritsyan, M. L.; Arutyunyan, B. S.; Esayan, K. A.

PATENT ASSIGNEE(S): USSR

SOURCE: U.S.S.R. From: Otkrytiya, Izobret., Prom.

Obraztsy, Tovarnye Znaki 1980, (27), 101.

CODEN: URXXAF

DOCUMENT TYPE:

Patent Russian

LANGUAGE: FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
	-			
SU 749837	A1	19800723	SU 1977-2507534	19770715
PRIORITY APPLN. INFO.:			SU 1977-2507534 A	19770715

ED Entered STN: 12 May 1984

GI

AB Isocyanuric acids I (R = p-C6H4CMe2C6H4OH-p, p-C6H4OH) have the title properties.

IT 76964-55-1

(adhesives)

RN 76964-55-1 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[2-hydroxy-3-(4-hydroxyphenoxy)propyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & & & & \\ & & & \\ & & & \\ &$$

- IC C07D251-34; C08K005-34
- CC 37-3 (Plastics Fabrication and Uses)
- IT **76964-55-1** 76964-56-2 (adhesives)

=> d his nofile

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                681440-12-0/BI OR 681440-13-1/BI OR 681440-14-2/BI OR
                681440-15-3/BI OR 681440-16-4/BI OR 681440-17-5/BI OR
                681440-19-7/BI OR 681440-20-0/BI OR 681440-21-1/BI OR
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                681440-25-5/BI OR 9002-88-4/BI)
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                STR
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           1699 SEA SUB=L4 SSS FUL L11
L13
L14
             14 SEA ABB=ON PLU=ON L13 AND L3
L15
              5 SEA ABB=ON PLU=ON L3 NOT L14
                SAV L13 LEE349/A
L16
                STR L7
L17
              0 SEA SUB=L13 SSS SAM L16
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             19 SEA SUB=L13 SSS FUL L16
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L19
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             50 SEA SUB=L13 SSS SAM L19
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           1272 SEA SUB=L13 SSS FUL L19
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L22
                STR L11
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              5 SEA SUB=L13 SSS SAM L22
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            179 SEA SUB=L13 SSS FUL L22
                SAV L24 LEE349C/A
L25
                STR L5
L26
              0 SEA SUB=L13 SSS SAM L25
L27
              0 SEA SUB=L13 SSS FUL L25
L28
              0 SEA SUB=L13 SSS SAM L25
L29
                STR L25
             50 SEA SUB=L4 SSS SAM L29
L30
L31
                STR L29
L32
              0 SEA SUB=L13 SSS SAM L31
L33
           1363 SEA SUB=L4 SSS FUL L29
             27 SEA SUB=L33 SSS SAM L31
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            457 SEA SUB=L33 SSS FUL L31
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                SAV L35 LEE349D/A
              O SEA ABB=ON PLU=ON L21 AND L24 AND L35
L36
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L37
           152 SEA ABB=ON PLU=ON L24
L38
            214 SEA ABB=ON
                            PLU=ON
                                    L35
L39
           2081 SEA ABB=ON PLU=ON L21
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L41	12	SEA ABB=ON	PLU=ON	L39 AND L38
L42	11	SEA ABB=ON	PLU=ON	L39 AND L37
L43	22	SEA ABB=ON	PLU=ON	(L41 OR L42)
L44	12	SEA ABB=ON	PLU=ON	L18

SCIENTITIC REFERENCE BR

Requester's Full Name:

Art Unit: 177-7 Requester's Full Name:

Art Unit: 1752 Phone Number 30 2-1333 Serial Number: 10 1530, 349

Mail Box and Bldg/Room Location: 9015 Results Format Preferred (circle): PAPER DISK E-MAIL (Rem.) If more than one search is submitted, please prioritize searches in order of need. Please provide a detailed statement of the search topic, and describe as specifically as possible the subject matter to be searched. Include the elected species or structures, keywords, synonyms, acronyms, and registry numbers, and combine with the concept or utility of the invention. Define any terms that may have a special meaning. Give examples or relevant citations, authors, etc, if known. Please attach a copy of the cover sheet, pertinent claims, and abstract. Title of Invention: P/z. See Bib Inventors (please provide full names): Earliest Priority Filing Date: *For Sequence Searches Only* Please include all pertinent information (parent, child, divisional, or issued patent numbers) along with the

appropriate serial number.

oligomer compound or triazme trione polyner compound having a structure in which at least two triazine trione rings are Inked through a linking gp. of formula (4) or (5) on the nitrogen atoms
(see c1. #1)

Amendments to the Claims:

The following listing of claims will replace all prior versions, and listings, of claims in the application:

characterized in that the composition comprises a triazine trione compound having hydroxyalkyl structure as substituent on nitrogen atom, a triazine trione oligomer compound having hydroxyalkyl structure as substituent on nitrogen atom, or a triazine trione polymer compound having hydroxyalkyl structure as substituent or nitrogen atom; wherein the triazine trione compound having hydroxyalkyl structure as substituent on nitrogen atom, the triazine trione oligomer compound having hydroxyalkyl structure as substituent on nitrogen atom, the triazine trione oligomer compound having hydroxyalkyl structure as substituent on nitrogen atom, or the triazine trione polymer compound having hydroxyalkyl structure as substituent on nitrogen atom is a triazine trione compound having a substituent of formula (2) or (3) as substituent on nitrogen atom, or a triazine trione oligomer compound or triazine trione polymer compound having a structure in which at least two triazine trione rings are linked through a linking group of formula (4) or (5) on the nitrogen atoms:

wherein A₁, A₂ and A₃ are independently of one another hydrogen atom, methyl or ethyl, each

Y is independently a direct bond or -C(=O)-, Ar is benzene ring or naphthalene ring which

may be substituted with C₁₋₆ alkyl, phenyl, naphthyl, halogen atom, C₁₋₆ alkoxycarbonyl,

nitro, carboxy, cyano, C₁₋₆ alkoxy, hydroxy, thiol, C₁₋₆ alkylthio or amino, Q is C₁₋₆ alkyl, C₅₋₈

cycloalkyl, Ar or -CH₂-Ar-CH₂-, R₁ is C₁₋₆ alkyl, phenyl or benzyl, R₂ is hydrogen atom, C₁₋₆

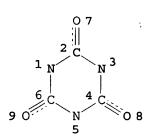
alkyl, phenyl or benzyl.

- 2-3. (Canceled)
- 4. (Currently Amended) The composition for forming anti-reflective coating according to claim 3, claim 1, wherein the triazine trione compound having a substituent of formula (2) or (3) has a structure of formula (6) or (7):

5. (Currently Amended) The composition for forming anti-reflective coating according to claim 3, claim 1, wherein the triazine trione oligomer compound or triazine trione polymer

=> d que 17

198713) SEA FILE=REGISTRY ABB=ON PLU=ON 46.492/RID L1 (L2 STR



14 OH @10 11 12 13

17 Ak√ COOH @15 16

G1 21

VAR G1=10/15/20 NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

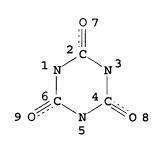
RSPEC I

NUMBER OF NODES IS 21

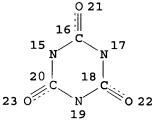
STEREO ATTRIBUTES: NONE

L3 L4

1699 SEA FILE=REGISTRY SUB=L1 SSS FUL L2



OH ~ C-~ C-~ O 10 11 12 13



NODE ATTRIBUTES:

DEFAULT MLEVEL IS ATOM

DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS

STEREO ATTRIBUTES: NONE

L6

19 SEA FILE=REGISTRY SUB=L3 SSS FUL L4

L7 6 SEA FILE=HCAPLUS ABB=ON PLU=ON L6

=> d 17 1-6 ibib ed abs hitstr hitind

ANSWER 1 OF 6 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

2004:333974 HCAPLUS

DOCUMENT NUMBER:

140:365660

```
TITLE:
                                Composition for forming antireflection film for
                                lithography
INVENTOR(S):
                                Kishioka, Takahiro; Mizusawa, Ken-ichi; Enomoto,
                                Tomoyuki; Sakamoto, Rikimaru; Nakayama, Keisuke;
                                Kawamura, Yasuo
PATENT ASSIGNEE(S):
                                Nissan Chemical Industries, Ltd., Japan
SOURCE:
                                PCT Int. Appl., 85 pp.
                                CODEN: PIXXD2
DOCUMENT TYPE:
                                Patent
LANGUAGE:
                                Japanese
FAMILY ACC. NUM. COUNT:
PATENT INFORMATION:
      PATENT NO.
                                KIND
                                         DATE
                                                        APPLICATION NO.
                                                                                      DATE
      -----
                                _ _ _ _
                                         _____
                                                        -----
      WO 2004034148
                                                        WO 2003-JP12875
                                         20040422
                                 A1
                                                                                      20031008
           W: AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU,
                 ZA, ZM, ZW
           RW: GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW, AM, AZ, BY, KG, KZ, MD, RU, TJ, TM, AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, NU, IE, IT, LU, MC, NL, PT, RO, SE, SI, SK, TR, BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR,
                 NE, SN, TD, TG
      AU 2003271123
                                         20040504
                                 Α1
                                                        AU 2003-271123
                                                                                      20031008
      EP 1560070
                                 A1
                                         20050803
                                                        EP 2003-751376
                                                                                      20031008
                AT, BE, CH, DE, DK, ES, FR, GB, GR, IT, LI, LU, NL, SE, MC, PT, IE, SI, LT, LV, FI, RO, MK, CY, AL, TR, BG, CZ, EE, HU, SK
      CN 1723418
                                 Α
                                         20060118
                                                       V CN 2003-80105388
                                                                                      20031008
PRIORITY APPLN. INFO.:
                                                         JP 2002-295777
                                                                                  A 20021009
                                                        JP 2003-126886
                                                                                  A 20030502
                                                        WO 2003-JP12875
                                                                                  W 20031008
ED
      Entered STN: 23 Apr 2004
AB
      A composition for forming an antireflection film comprises a compound, an
      oligomer or a polymer comprising a triazine-trione moiety having a
      hydroxyalkyl structure as a substitute on a nitrogen atom. The composition
      can provide an antireflection film which exhibits good absorptivity
      for a light having a wavelength suitable for use in the production of a
      semiconductor device, has high antireflection effect, and exhibits a
      dry etching rate greater than that of a photoresist layer.
IT
      681440-20-0P
          (oligomeric; photolithog antireflective film compns. containing)
RN
      681440-20-0 HCAPLUS
      Poly[(dihydro-5-methyl-2,4,6-trioxo-1,3,5-triazine-1,3(2H,4H)-diyl)(4-
CN
      oxo-1,4-butanediyl)oxy(2-hydroxy-1,3-propanediyl)[dihydro-2,4,6-trioxo-
      5-(2-propenyl)-1,3,5-triazine-1,3(2H,4H)-diyl](2-hydroxy-1,3-
      propanediyl)oxy(1-oxo-1,4-butanediyl)] (9CI) (CA INDEX NAME)
```

PAGE 1-B

IT 681440-21-1P 681440-22-2P

(photolithog antireflective film compns. containing)

- RN 681440-21-1 HCAPLUS
- CN 1,3,5-Triazine-1(2H)-butanoic acid, tetrahydro-3,5-dimethyl-2,4,6-trioxo-, (2,4,6-trioxo-1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tris(2-hydroxy-3,1-propanediyl) ester (9CI) (CA INDEX NAME)

Me N—
$$(CH_2)_3$$
 — C — C

PAGE 1-B

PAGE 2-A

RN 681440-22-2 HCAPLUS

CN

1,3,5-Triazine-1(2H)-acetic acid, tetrahydro-3,5-dimethyl-2,4,6-trioxo-, (2,4,6-trioxo-1,3,5-triazine-1,3,5(2H,4H,6H)-triyl)tris(2-hydroxy-3,1-propanediyl) ester (9CI) (CA INDEX NAME)

PAGE 1-B

PAGE 2-A

- IC ICM G03F007-11 ICS H01L021-027
- CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 76

IT 681440-09-5P 681440-10-8P 681440-11-9P 681440-12-0P 681440-13-1P 681440-14-2P 681440-15-3P 681440-16-4P

```
681440-17-5P
             681440-19-7P 681440-20-0P
```

7

(oligomeric; photolithog antireflective film compns. containing)

IT 681440-21-1P 681440-22-2P 681440-23-3P

(photolithog antireflective film compns. containing)

REFERENCE COUNT:

THERE ARE 7 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L7 ANSWER 2 OF 6 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

2004:305563 HCAPLUS

DOCUMENT NUMBER:

140:329574

TITLE:

Heat- or photo-curable composition for negative-working lithograph/c plate

INVENTOR(S):

Fujimaki, Kazuhiro

PATENT ASSIGNEE(S): SOURCE:

Fuji Photo Film Co., Ltd./, Japan Jpn. Kokai Tokkyo Koho, 94 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
		/		
JP 2004117555	Α	20040415/	JP 2002-277719	20020924
PRIORITY APPLN. INFO.:			JP 2002-277719	20020924

ED Entered STN: 15 Apr 2004

The composition contains (A) a polymerizable compound having ≥ 1 AΒ ethylenic unsatd. group and ≥2 kyclic structures from ≥1 amide structure and (B) a compound generating radical by heat or light. The composition shows good storage stability, high sensitivity, developability, and gives neg. lithog. printing plate with good printing durability especially on burning treatment.

ΙT 679408-24-3P 679408-26-5P

(heat- or photo-curable/composition for neg.-working lithog. plate)

RN 679408-24-3 HCAPLUS

> 1,4-Cyclohexanedicarboxyl/c acid, bis[3-[3,5-bis[2,3-bis[(1-oxo-2propenyl)oxy]propyl]tetrapydro-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2hydroxypropyl] ester, pólymer with 1,2-ethanediyl bis(2-methyl-2propenoate), methyl 2-methyl-2-propenoate, 2-methyl-2-propenamide and 2-methyl-2-propenoic acid (9CI) (CA INDEX NAME)

CM 1

CN

CRN 679408-11-8 CMF C56 H66 N6 O28

$$\begin{array}{c} \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} \\ \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} - \text{CH}_2 - \text{CH} - \text{CH}_2 \\ \text{O} \\ \text{O} \\ \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} - \text{CH}_2 - \text{CH} - \text{CH}_2 \\ \text{O} \\ \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} - \text{CH}_2 - \text{CH} - \text{CH}_2 \\ \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} \\ \text{O} \\ \end{array}$$

PAGE 1-B

CM 2

CRN 97-90-5 CMF C10 H14 O4

CM 3

CRN 80-62-6 CMF C5 H8 O2

CM 4

CRN 79-41-4 CMF C4 H6 O2

$$\begin{array}{c} \text{CH}_2 \\ || \\ \text{Me-- C-- CO}_2\text{H} \end{array}$$

CM 5

CRN 79-39-0 CMF C4 H7 N O

$$\begin{array}{c|c} ^{H_2C} & \text{O} \\ \parallel & \parallel \\ \text{Me-} \text{C-} \text{C-} \text{NH}_2 \end{array}$$

CN

RN 679408-26-5 HCAPLUS

1,3,5-Benzenetricarboxylic acid, tris[2-hydroxy-3-[tetrahydro-3,5-bis[3-[(2-methyl-1-oxo-2-propenyl)oxy]-2-[(1-oxo-2-propenyl)oxy]propyl]-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]propyl] ester, polymer with 1,2-ethanediyl bis(2-methyl-2-propenoate), methyl 2-methyl-2-propenoate, 2-methyl-2-propenoic acid (9CI) (CA INDEX NAME)

CM 1

CRN 679408-12-9 CMF C87 H99 N9 O42

PAGE 1-B

OH
$$CH_2 - CH - CH_2 - CH_2 - CH - CH_2 - CH_2$$

PAGE 2-B

$$\begin{array}{c|c} & \text{O} & \text{CH}_2 \\ & || & || \\ & || & || \\ & \text{CH}_2 - \text{CH} - \text{CH}_2 - \text{O} - \text{C} - \text{C} - \text{Me} \\ & || & \\ & \text{O} - \text{C} - \text{CH} = \text{CH}_2 \\ & || & \\ & \text{O} \end{array}$$

CM 2

CRN 97-90-5 CMF C10 H14 O4

CM 3

CRN 80-62-6 CMF C5 H8 O2

$$\begin{array}{ccc} ^{H_2C} & \text{O} \\ & || & || \\ \text{Me-} & \text{C-} & \text{C-} & \text{OMe} \end{array}$$

CM 4

CRN 79-41-4 CMF C4 H6 O2

$$\begin{array}{c} \text{CH}_2 \\ || \\ \text{Me-C-CO}_2 \text{H} \end{array}$$

CM 5

CRN 79-39-0 CMF C4 H7 N O

$$H_2C O | H_2C O |$$
 $H_1 H_2 C O O O$
 $H_2 C O O O$

IT 679408-11-8 679408-12-9

(heat- or photo-curable composition for neg.-working lithog. plate)

RN 679408-11-8 HCAPLUS

CN 1,4-Cyclohexanedicarboxylic acid, bis[3-[3,5-bis[2,3-bis[(1-oxo-2-propenyl)oxy]propyl]tetrahydro-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]-2-hydroxypropyl] ester (9CI) (CA INDEX NAME)

PAGE 1-A

$$\begin{array}{c} \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} \\ \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} - \text{CH}_2 - \text{CH} - \text{CH}_2 \\ \text{O} \\ \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} - \text{CH}_2 - \text{CH} - \text{CH}_2 \\ \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} - \text{CH}_2 - \text{CH} - \text{CH}_2 \\ \text{H}_2\text{C} = \text{CH} - \text{C} - \text{O} \\ \text{O} \\ \end{array}$$

PAGE 1-B

PAGE 1-A

RN 679408-12-9 HCAPLUS

CN 1,3,5-Benzenetricarboxylic acid, tris[2-hydroxy-3-[tetrahydro-3,5-bis[3-[(2-methyl-1-oxo-2-propenyl)oxy]-2-[(1-oxo-2-propenyl)oxy]propyl]-2,4,6-trioxo-1,3,5-triazin-1(2H)-yl]propyl] ester (9CI) (CA INDEX NAME)

PAGE 1-B

PAGE 2-B

IC ICM G03F007-027

ICS C08F020-36; G02B005-20; G03F007-00; G03F007-004

CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 38

IT 679407-95-5P 679408-01-6P 679408-08-3P 679408-15-2P 679408-18-5P 679408-16-3P 679408-17-4P 679408-19-6P 679408-20-9P 679408-21-0P 679408-22-1P 679408-23-2P 679408-24-3P 679408-25-4P 679408-26-5P 679408-27-6P 679408-28-7P 679408-29-8P 679408-30-1P (heat- or photo-curable composition for neg.-working lithog. plate)

679408-31-2P 679408-32-3P 679408-33-4P 679408-34-5P 679408-35-6P

(heat- or photo-curable composition for neg.-working lithog. plate) 679407-93-3 IT 679407-94-4 679407-96-6 679407-97-7 679407-98-8 679407-99-9 679408-00-5 679408-02-7 679408-03-8 679408-04-9 679408-05-0 679408-06-1 679408-07-2 679408-09-4 679408-10-7

679408-11-8 679408-12-9 679408-13-0 679408-14-1

L7 ANSWER 3 OF 6 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1987:477891 HCAPLUS

DOCUMENT NUMBER: 107:77891

TITLE: New organosilicon bis-derivatives of isocyanuric

acid

AUTHOR(S): Eritsyan, M. L.; Karamyan, R. A.; Khananashvili,

L. M.

CORPORATE SOURCE: Tbilis. Gos. Univ., Tbilisi, USSR

SOURCE: Soobshcheniya Akademii Nauk Gruzinskoi SSR (1986),

123(3), 549-52

CODEN: SAKNAH; ISSN: 0002-3167

DOCUMENT TYPE: Journal LANGUAGE: Russian

OTHER SOURCE(S): CASREACT 107:77891

ED Entered STN: 05 Sep 1987

GI

AB Silylbis(isocyanurate) I (R = H) was prepared in 85% yield by treating monosodium isocyanurate with Me2SiCl2. Treating I (R = H) with HCHO and oxiranes II (R1 = Cl, PhO) gave 65-96% I [R = CH2OH, CH2CH(OH)CH2R1], which, on treatment with maleic anhyddride gave 93-97% I [R = CH2O2CCH:CHCO2H; CH2CH(CH2R1)O2CCH:CHCO2H].

IT 109636-40-0P

(preparation and reaction of, with maleic anhydride)

RN 109636-40-0 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,1'-(dimethylsilylene)bis[3,5-bis(2-hydroxy-3-phenoxypropyl)- (9¢I) (CA INDEX NAME)

USHA SHRESTHA EIC 1700 REM 4B31

CC 29-6 (Organometallic and Organometalloidal Compounds)

IT 109636-38-6P 109636-39-7P 109636-40-0P

(preparation and reaction of, with maleic anhydride)

L7 ANSWER 4 OF 6 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1984:184725 HCAPLUS

DOCUMENT NUMBER: 100:184725

TITLE: Organometallic complexes based on tris-substituted

derivatives of isocyanuric acid

AUTHOR(S): Eritsyan, M. L.; Karamyan, R. A.; Eritsyan, N. P.;

Karapetyan, K. A.

CORPORATE SOURCE: Gos. Nauchno-Issled. Proektn. Inst. Polim. Kleev,

Kirovakan, USSR

SOURCE: Koordinatsionnaya Khimiya (1984), 10(2), 195-200

CODEN: KOKHDC; ISSN: 0132-344X

DOCUMENT TYPE: Journal LANGUAGE: Russian

ED Entered STN: 26 May 1984

AB [CoL2Q2]n [HL = tris-1,3,5-(2'-hydroxy-3'-chloropropyl)isocyanuric

acid (I), Q = NH3; HL = tris-1,3,5-(2'-hydroxy-3'-

phenoxypropyl)isocyanuric acid (II), tris-1,3,5-[(2'-hydroxy-3'-phenoxypropoxy)methyl]isocyanuric acid (III), Q = NH3, Et2NH, HN(C2H4OH)2] and [CuL2Q2]n [HL = I, Q = NH3; HL = tris-1,3,5-

(hydroxymethyl)isocyanuric acid, II, III, Q = NH3, Et2NH, HN(C2H4OH)2] were prepared and characterized by IR spectra. [CoL2]n and [CuL2]n were also prepared

IT 89527-97-9P 89527-99-1P

(preparation and reactions with amines or alc. amines)

RN 89527-97-9 HCAPLUS

CN Cobalt, bis[1,3,5-tris[(2-hydroxy-3-phenoxypropoxy)methyl]-1,3,5-triazine-2,4,6(1H,3H,5H)-trionato]-, (T-4)- (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2-\text{O-CH}_2-\text{CH-CH}_2-\text{OPh} \\ \hline & \text{O} \\ & \text{O} \\ & \text{OH} \\ & \text{OH} \\ & \text{CH}_2-\text{O-CH}_2-\text{CH-CH}_2-\text{OPh} \\ & \text{O} \end{array}$$

RN 89527-99-1 HCAPLUS

CN Copper, bis[1,3,5-tris[(2-hydroxy-3-phenoxypropoxy)methyl]-1,3,5-triazine-2,4,6(1H,3H,5H)-trionato]- (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2-\text{O-CH}_2-\text{CH-CH}_2-\text{OPh} \\ \hline & \text{O} \\ & \text{O} \\ & \text{CH}_2-\text{O-CH}_2-\text{CH-CH}_2-\text{OPh} \\ \hline & \text{CH}_2-\text{O-CH}_2-\text{CH-CH}_2-\text{OPh} \\ & \text{O} \end{array}$$

IT 89527-94-6P 89528-26-7P 89551-34-8P 89741-97-9P

(preparation of)

RN 89527-94-6 HCAPLUS

CN Copper, diamminebis[1,3,5-tris[(2-hydroxy-3-phenoxypropoxy)methyl]-1,3,5-triazine-2,4,6(1H,3H,5H)-trionato]- (9CI) (CA INDEX NAME)

PAGE 1-B

RN 89528-26-7 HCAPLUS

CN Cobalt, diamminebis[1,3,5-tris[(2-hydroxy-3-phenoxypropoxy)methyl]-1,3,5-triazine-2,4,6(1H,3H,5H)-trionato]- (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

RN 89551-34-8 HCAPLUS

CN Cobalt, bis(N-ethylethanamine)bis[1,3,5-tris[(2-hydroxy-3-phenoxypropoxy)methyl]-1,3,5-triazine-2,4,6(1H,3H,5H)-trionato]- (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

PAGE 1-A

$$\begin{array}{c} \text{PhO-CH}_2-\text{CH-CH}_2-\text{O-CH}_2 \\ \text{OH} \\ \text{OH} \\ \text{PhO-CH}_2-\text{CH-CH}_2-\text{O-CH}_2 \\ \text{O} \\ \text{O} \\ \text{N-CH}_2-\text{O-CH}_2 \\ \text{O} \\ \text{Ph} \\ \text{Ph} \\ \text{Ph} \\ \text{NH-Et} \\ \text{Et} \\ \end{array}$$

PAGE 1-B

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2-\text{O}-\text{CH}_2-\text{CH}-\text{CH}_2-\text{OPh} \\ \\ & \text{O} \\ & \text{OH} \\ & \text{CH}_2-\text{O}-\text{CH}_2-\text{CH}-\text{CH}_2-\text{OPh} \\ \\ & \text{O} \\ \end{array}$$

CC 78-7 (Inorganic Chemicals and Reactions)

IT 89527-96-8P 89527-97-9P 89527-98-0P 89527-99-1P

89551-31-5P 89551-32-6P 89729-12-4P

(preparation and reactions with amines or alc. amines)

IT 111-42-2DP, cobalt and copper complexes 7440-48-4DP, complexes with
isocyanuric acid derivs. 7440-50-8DP, complexes with isocyanuric
acid derivs. 10471-40-6DP, cobalt and copper complexes
17989-80-9DP, cobalt and copper complexes 75513-67-6DP, cobalt and
copper complexes 89527-93-5P 89527-94-6P 89527-95-7P
89528-24-5P 89528-25-6P 89528-26-7P 89551-29-1P
89551-30-4P 89551-33-7P 89551-34-8P 89741-97-9P
89933-39-1P

(preparation of)

L7 ANSWER 5 OF 6 HCAPLUS COPYRIGHT 2007 ACS on STN ACCESSION NUMBER: 1977:603166 HCAPLUS

DOCUMENT NUMBER:

87:203166

TITLE:

Diallylisocyanuric acid derivatives as modifiers

for latex coatings

INVENTOR(S):

Zalinyan, M. G.; Avetisyan, G. V.; Arutyunyan, B.

S.; Eritsyan, M. L.; Movsisyan, G. V.

PATENT ASSIGNEE(S):

State Scientific-Research and Design Institute of

Polymeric Adhesives, USSR

SOURCE:

U.S.S.R. From: Otkrytiya, Izobret., Prom. Obraztsy, Tovarnye Znaki 1977, 54(31), 64.

CODEN: URXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Russian

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO. KIND DATE APPLICATION NO. DATE

SU 569574 A1 19770825 SU 1975-2170870 19750910
PRIORITY APPLN. INFO.: SU 1975-2170870 A 19750910

ED Entered STN: 12 May 1984

GI

$$CH_2 = CHCH_2N \qquad NCH_2CH (OH) CH_2O - CMe_2 - CMe_2 - OCH_2R$$

$$O = CH_2CH = CH_2$$

$$CH_2CH = CH_2$$

AB Isocyanurate derivs. [I, R = oxiranyl, 1-hydroxy-2-(2,4,6-trioxo-3,5-diallylhexahydro-1-triazinyl)ethyl] are modifiers for latex coatings.

IT 64936-28-3

(modifiers, for latex coatings)

RN 64936-28-3 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,1'-[(1-methylethylidene)bis[4,1-phenyleneoxy(2-hydroxy-3,1-propanediyl)]]bis[3,5-di-2-propenyl-(9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

$$\begin{array}{c|c} \text{CH}_2-\text{CH} \longrightarrow \text{CH}_2 \\ \text{OH} & \text{O} \\ \text{OH} & \text{O} \\ \text{-CH}-\text{CH}_2-\text{N} & \text{N} \\ \text{O} & \text{CH}_2-\text{CH} \longrightarrow \text{CH}_2 \\ \text{O} \end{array}$$

IC C07D251-34

CC 42-7 (Coatings, Inks, and Related Products)

IT 64819-57-4 64936-28-3

(modifiers, for latex coatings)

L7 ANSWER 6 OF 6 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1977:140859 HCAPLUS

DOCUMENT NUMBER:

86:140859

TITLE:

Study of the hardening of oligoesters with

unsaturated end groups containing an s-triazine

ring

AUTHOR (S):

Kutepov, D. F.; Borisova, L. N.; Skubin, V. K.;

Basov, M. I.

CORPORATE SOURCE:

Mosk. Khim.-Tekhnol. Inst. im. Mendeleeva, Moscow,

TICCD

SOURCE:

Deposited Doc. (1974), VINITI 2034-74, 15 pp.

Avail.: BLLD

DOCUMENT TYPE:

Report

LANGUAGE:

Russian

ED Entered STN: 12 May 1984

GI

AB Homopolymn. of a triazine-containing acrylate (I, R = CH2:CHCO2) [38817-87-7] and methacrylate (I, R = CH2:CMeCO2) [54316-76-6], and of their ethylene glycol-modified analogs [II (R = CH2:CHCO2, Z = OCH2CH2O) [62202-54-4] and II (R = CH2:CMeCO2, Z = OCH2CH2O)

[62228-34-6]] or diethylene glycol-modified analogs [II [R = CH2:CHCO2, Z = (OCH2CH2)20] [62202-55-5] and II [R = CH2:CMeCO2, Z = (OCH2CH2)20] [62202-56-6]] followed 1st order kinetics with variable rate consts. The observed decrease in the rate constant in the course of the polymerization was not accompanied by a change in the reaction order and indicated that at a given conversion stage the propagation step became diffusion controlled. This autoretardation occurred at lower conversions for the methacrylates than for the acrylates. The optimum conditions of the polymerization were determined (best catalyst methyl ethyl ketone peroxide [1338-23-4]). Comparison of thermal stability of the resulting polymers with that of TGM-3 and MGF-9 indicated beneficial effects from the presence of the triazine rings.

IT 62202-54-4 62202-55-5 62202-56-6 62228-34-6

(polymerization of, kinetics of)

RN 62202-54-4 HCAPLUS

CN 2-Propenoic acid, 1,2-ethanediylbis[oxy(2-hydroxy-3,1-propanediyl)[(2,4,6-trioxo-1,3,5-triazine-5,1,3(2H,4H,6H)-triyl)bis(2-hydroxy-3,1-propanediyl)]] ester (9CI) (CA INDEX NAME)

RN 62202-55-5 HCAPLUS

CN 2-Propenoic acid, [oxybis[2,1-ethanediyloxy(2-hydroxy-3,1-propanediyl)(2,4,6-trioxo-1,3,5-triazine-5,1,3(2H,4H,6H)-triyl)bis(2-hydroxy-3,1-propanediyl)]] ester (9CI) (CA INDEX NAME)

PAGE 1-B

PAGE 1-B

RN 62202-56-6 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, [oxybis[2,1-ethanediyloxy(2-hydroxy-3,1-propanediyl)(2,4,6-trioxo-1,3,5-triazine-5,1,3(2H,4H,6H)-triyl)bis(2-hydroxy-3,1-propanediyl)]] ester (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

RN 62228-34-6 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 1,2-ethanediylbis[oxy(2-hydroxy-3,1-propanediyl)(2,4,6-trioxo-1,3,5-triazine-5,1,3(2H,4H,6H)-triyl)bis(2-hydroxy-3,1-propanediyl)] ester (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

CC 36-6 (Plastics Manufacture and Processing)
IT 38817-87-7 54316-76-6 62202-54-4 62202-55-5
62202-56-6 62228-34-6
(polymerization of, kinetics of)

=> d his nofile

(FILE 'HOME' ENTERED AT 10:21:08 ON 15 AUG 2007)

FILE 'REGISTRY' ENTERED AT 10:45:43 ON 15 AUG 2007 ACT LEE349/A

L1 (198713)SEA ABB=ON PLU=ON 46.492/RID L2 STR L3 1699 SEA SUB=L1 SSS FUL L2

L4 STR L2
L5 1 SEA SUB=L3 SSS SAM L4
L6 19 SEA SUB=L3 SSS FUL L4
SAV L6 LEE349E/A

FILE 'HCAPLUS' ENTERED AT 10:50:36 ON 15 AUG 2007 L7 6 SEA ABB=ON PLU=ON L6 NIG 09 RELUS Scientific and Technical Information Center

SEARCH REQUEST FORM

thos whice				
Requester's Full Name 8 7.M Sin Art Unit: 1752 Phone Numb Mail Box and Bldg/Room Location:	J. Lee	Examiner	#:	-7-07
Art Unit: 1752 Phone Num	ber 30 2-1333	Seria	l Number: <u>10[530,3</u>	49
Mail Box and Bldg/Room Location:	9015 Resi	ılts Format	Preferred (circle): PAPER DIS	SK E-MAIL
If more than one search is submitted	(Kem.) d, please prioritiz	e searche	s in order of need.	
Please provide a detailed statement of the search Include the elected species or structures, keyword utility of the invention. Define any terms that a known. Please attach a copy of the cover sheet,	ords, synonyms, acror may have a special me	yms, and regeaning. Give	istry numbers, and combine with the	concept or
Title of Invention:	P12.	Ale	Bib.	
Inventors (please provide full names):	•			

Please Search for the reaction product of. C1. #6



United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Viginus 22313-1450 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 7775

SERIAL NUMBER 10/530,349	FILING OR 371(c) DATE 04/06/2005 RULE	CLASS 430	GROUP ART UN 1752	ATTO	PRNEY DOCKET NO. 123418
Ken-ichi Mizusaw Tomoyuki Enomo Rikimaru Sakamo Keisuke Nakayam Yasuo Kawamura	n, Nei-gun, JAPAN; a, Chiyoda-ku, JAPAN; to, Nei-gun, JAPAN; to, Nei-gun, JAPAN; na, Nei-gun, JAPAN; , Funabashi-shi, JAPAN;				
** FOREIGN APPLICATI JAPAN 2002-295 JAPAN 2003-1260	a 371 of PCT/JP03/12875 ONS ************************************				·
Verified and Acknowledged Ex	yes no Met after A	ZA JAPAN	SHEETS DRAWING 0	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 1
ADDRESS 25944	·				
TITLE Composition for forming a	anti-reflective coating for us	e in lithography			_
RECEIVED No	: Authority has been given i to charge/credit [for following:	n Paper DEPOSIT ACCOUNT	All Fees 1.16 Fee 1.17 Fee 1.18 Fee Other Credit	s (Processin	g Ext. of time)

compound having a structure in which at least two triazine trione rings are linked through a linking group of formula (4) or (5) on the nitrogen atoms has a structure of formula (8) or (9):

6. (Currently Amended) The composition A composition for forming antireflective coating characterized in that the composition comprises a triazine trione compound
having hydroxyalkyl structure as substituent on nitrogen atom, a triazine trione oligomer
compound having hydroxyalkyl structure as substituent on nitrogen atom, or a triazine trione
polymer compound having hydroxyalkyl structure as substituent on nitrogen atom; and for
forming anti-reflective coating according to claim 1, wherein the triazine trione oligomer
compound having hydroxyalkyl structure as substituent on nitrogen atom, or triazine trione
polymer compound having hydroxyalkyl structure as substituent on nitrogen atom is a
reaction product of a compound of formula (10) with a compound of formula (11) or (12):

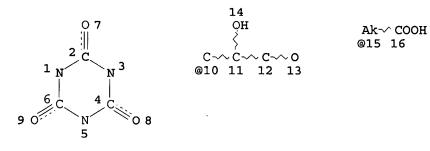
wherein R_3 is C_{1-6} alkyl, C_{3-6} alkenyl, phenyl, benzyl or 2,3-epoxypropyl, R_4 and R_5 are C_{1-6} alkyl, C_{3-6} alkenyl, phenyl or benzyl, R_6 is C_{1-6} alkyl, phenyl, benzyl or -(CH₂)_nCOOH, and n is a number of 1, 2 or 3.

7. (Currently Amended) The composition for forming anti-reflective coating according to elaim 3, claim 1, wherein the triazine trione compound having a substituent of formula (2) as substituent on nitrogen atom, or the triazine trione oligomer compound or triazine trione polymer compound having a structure in which at least two triazine trione rings are linked through a linking group of formula (4) on the nitrogen atoms is produced from a triazine trione compound having at least two nitrogen atoms having a substituent of formula (13) on nitrogen atom and a phenyl compound or naphthalene compound of formula (14) having at least two substituents selected from carboxy and hydroxy which are identical or different from each other

=> d que 140

L4 198713 SEA FILE=REGISTRY ABB=ON PLU=ON 46.492/RID STR

L11



G1 21

VAR G1=10/15/20 NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

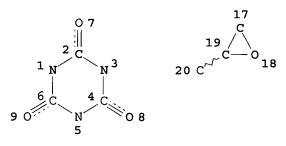
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NUMBER OF NODES IS 21

STEREO ATTRIBUTES: NONE

L13 1699 SEA FILE=REGISTRY SUB=L4 SSS FUL L11

L19



NODE ATTRIBUTES:

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DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS

STEREO ATTRIBUTES: NONE

L21 1272 SEA FILE=REGISTRY SUB=L13 SSS FUL L19

L22 STR

Ak~ COOH @15 16

VPA 15-1/3/5 U NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS 11

STEREO ATTRIBUTES: NONE

L24

179 SEA FILE=REGISTRY SUB=L13 SSS FUL L22

L29 ST

NODE ATTRIBUTES:

DEFAULT MLEVEL IS ATOM

DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS 9

STEREO ATTRIBUTES: NONE

L31

STR

NODE ATTRIBUTES:

DEFAULT MLEVEL IS ATOM

DEFAULT ECLEVEL IS LIMITED

USHA SHRESTHA EIC 1700 REM 4B31

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GRAPH ATTRIBUTES:
RSPEC I
NUMBER OF NODES IS
STEREO ATTRIBUTES: NONE
L33
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L35
             457 SEA FILE=REGISTRY SUB=L33 SSS FUL L31
             152 SEA FILE=HCAPLUS ABB=ON PLU=ON L24
L37
L38
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L39
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                                            PLU=ON
                                                     L21
               1 SEA FILE=HCAPLUS ABB=ON PLU=ON L37 AND L38 AND L39
L40
=> d 140 ibib ed abs hitstr hitind
L40 ANSWER 1 OF 1 HCAPLUS COPYRIGHT 2007 ACS on STN
ACCESSION NUMBER:
                         2004:333974 HCAPLUS
DOCUMENT NUMBER:
                           140:365660
TITLE:
                           Composition for forming antireflection film for
                           lithography
INVENTOR(S):
                           Kishioka, Takahiro; Mizusawa, Ken-ichi; Enomoto,
                           Tomoyuki; Sakamoto, Rikimaru; Nakayama, Keisuke;
                           Kawamura, Yasuo
PATENT ASSIGNEE(S):
                           Nissan Chemical Industries, Ltd., Japan
                           PCT Int. Appl., 85 pp.
SOURCE:
                           CODEN: PIXXD2
DOCUMENT TYPE:
                           Patent
LANGUAGE:
                           Japanese
FAMILY ACC. NUM. COUNT:
PATENT INFORMATION:
     PATENT NO.
                           KIND
                                   DATE
                                               APPLICATION NO.
                                                                         DATE
                           ----
                                                ----
                                  -----
                                  20040422
                                               WO 2003-JP12875
     WO 2004034148
                           A1
         W: AE, AG, AL, AM, AT, AU, AZ, BA, PB, BG, BR, BY, BZ, CA, CH,
              CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB,
              GD, GE, GH, GM, HR, HU, ID, IL/IN, IS, JP, KE, KG, KR, KZ,
              LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ,
              NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU,
              ZA, ZM, ZW
         RW: GH, GM, KE, LS, MW, MZ, SØ, SL, SZ, TZ, UG, ZM, ZW, AM, AZ,
              BY, KG, KZ, MD, RU, TJ, MM, AT, BE, BG, CH, CY, CZ, DE, DK,
              EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE, SI, SK, TR, BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR,
              NE, SN, TD, TG
             271123 A1 20040504 AU 2003-271123 200310
0070 A1 20050803 EP 2003-751376 200310
AT, BE, CH, DE, DK, ES, FR, GB, GR, IT, LI, LU, NL, SE, MC,
     AU 2003271123
     EP 1560070
              PT, IE, SI, LT, LV, FI, RO, MK, CY, AL, TR, BG, CZ, EE, HU, SK
     CN 1723418
                           Α
                                20060118
                                               CN 2003-80105388
                                                                         20031008
PRIORITY APPLN. INFO.:
                                                JP 2002-295777
                                                                      A 20021009
                                                JP 2003-126886
                                                                    A 20030502
                                                WO 2003-JP12875
                                                                     W 20031008
```

ED Entered STN: 23 Apr 2004

AB A composition for forming an antireflection film comprises a compound, an

oligomer or a polymer comprising a triazine-trione moiety having a hydroxyalkyl structure as a substitute on a nitrogen atom. The composition can provide an antireflection film which exhibits good absorptivity for a light having a wavelength suitable for use in the production of a semiconductor device, has high antireflection effect, and exhibits a dry etching rate greater than that of a photoresist layer.

681440-09-5P 681440-10-8P 681440-11-9P 681440-12-0P 681440-14-2P 681440-16-4P

681440-19-7P

(oligomeric; photolithog antireflective film compns. containing)

RN 681440-09-5 HCAPLUS
CN 2-Naphthalenecarboxylic

2-Naphthalenecarboxylic acid, 6-hydroxy-, polymer with
1,3,5-tris(oxiranylmethyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI)
(CA INDEX NAME)

CM 1

IT

CRN 16712-64-4 CMF C11 H8 O3

CM 2

CRN 2451-62-9 CMF C12 H15 N3 O6

RN 681440-10-8 HCAPLUS

Benzoic acid, 2,4,6-tribromo-3-hydroxy-, polymer with
1,3,5-tris(oxiranylmethyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI)
 (CA INDEX NAME)

CM 1

CN

CRN 14348-40-4 CMF C7 H3 Br3 O3

CRN 2451-62-9 CMF C12 H15 N3 O6

RN 681440-11-9 HCAPLUS

CN Benzoic acid, 2-hydroxy-3,5-diiodo-, polymer with 1,3,5-tris(oxiranylmethyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 2451-62-9 CMF C12 H15 N3 O6

CM 2

CRN 133-91-5 CMF C7 H4 I2 O3

RN 681440-12-0 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with 1-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c}
CH_2-CH \longrightarrow CH_2\\
\hline
O & N & O\\
\hline
O & CH_2-N & N \longrightarrow CH_2-N
\end{array}$$

CM 2

CRN 3030-60-2 CMF C6 H7 N3 O3

RN 681440-14-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with 1-phenyl-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH = CH_2 \\ \hline \\ O \\ CH_2-N \\ \hline \\ O \\ \end{array}$$

CRN 5725-46-2 CMF C9 H7 N3 O3

RN 681440-16-4 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with 1-methyl-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH \longrightarrow CH_2 \\ \hline \\ O \\ CH_2-N \\ \hline \\ O \\ \end{array}$$

CM 2

CRN 6726-47-2 CMF C4 H5 N3 O3

RN 681440-19-7 HCAPLUS

CN1,3,5-Triazine-1,3(2H,4H)-dibutanoic acid, dihydro-5-methyl-2,4,6trioxo-, polymer with 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-1,3,5triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM

CRN 681440-18-6 CMF C12 H17 N3 O7

CM 2

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline \\ O \\ CH_2-N \\ \hline \\ O \\ \end{array}$$

IT 681440-23-3P

(photolithog antireflective film compns. containing)

RN681440-23-3 HCAPLUS

CN 2-Naphthalenecarboxylic acid, 3,7-dihydroxy-, polymer with 1,3,5-tris(oxiranylmethyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 83511-07-3 CMF C11 H8 O4

CRN 2451-62-9 CMF C12 H15 N3 O6

RN 2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

$$\begin{array}{c|c}
CH_2 & N & CH_2 \\
\hline
O & N & CH_2
\end{array}$$

IT 681440-24-4 681440-25-5

(reaction with tris(2,3-epoxypropyl) isocyanurate in preparation of antireflective coating composition component)

RN 681440-24-4 HCAPLUS

CN 1,3,5-Triazine-1(2H)-butanoic acid, tetrahydro-3,5-dimethyl-2,4,6-trioxo- (9CI) (CA INDEX NAME)

RN 681440-25-5 HCAPLUS

CN 1,3,5-Triazine-1(2H)-acetic acid, tetrahydro-3,5-dimethyl-2,4,6-trioxo-(9CI) (CA INDEX NAME)

IC ICM G03F007-11

ICS H01L021-027

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 76

IT 681440-09-5P 681440-10-8P 681440-11-9P

681440-12-0P 681440-13-1P 681440-14-2P

681440-15-3P 681440-16-4P 681440-17-5P

681440-19-7P 681440-20-0P

(oligomeric; photolithog antireflective film compns. containing)

IT 681440-21-1P 681440-22-2P 681440-23-3P

(photolithog antireflective film compns. containing)

IT 2451-62-9, Tris(2,3-epoxypropyl)isocyanurate

(reaction with carboxyalkyldimethylisocyanuric acids in preparation of antireflective coating composition component)

IT 681440-24-4 681440-25-5

(reaction with tris(2,3-epoxypropyl) isocyanurate in preparation of antireflective coating composition component)

REFERENCE COUNT:

THERE ARE 7 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

=> d que 143

L4 198713 SEA FILE=REGISTRY ABB=ON PLU=ON 46.492/RID

L11 STR

Ak~ COOH @15 16

G1 21

VAR G1=10/15/20 NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS 21

STEREO ATTRIBUTES: NONE

L13 1699 SEA FILE=REGISTRY SUB=L4 SSS FUL L11 L19 STR

9 0 N S 19 C O

NODE ATTRIBUTES:

DEFAULT MLEVEL IS ATOM

DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS 13

STEREO ATTRIBUTES: NONE

L21 1272 SEA FILE=REGISTRY SUB=L13 SSS FUL L19

L22 STR

VPA 15-1/3/5 U NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

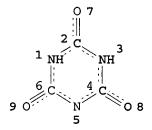
RSPEC I

NUMBER OF NODES IS 11

STEREO ATTRIBUTES: NONE

L24 179 SEA FILE=REGISTRY SUB=L13 SSS FUL L22

L29 STR



NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

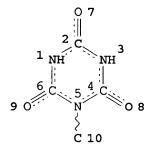
GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS

STEREO ATTRIBUTES: NONE

L31 STR



NODE ATTRIBUTES: DEFAULT MLEVEL IS ATOM DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RSPEC I

NUMBER OF NODES IS 10

STEREO ATTRIBUTES: NONE

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L41 12 SEA FILE=HCAPLUS ABB=ON PLU=ON L39 AND L38 L42 11 SEA FILE=HCAPLUS ABB=ON PLU=ON L39 AND L37 L43 22 SEA FILE=HCAPLUS ABB=ON PLU=ON (L41 OR L42)
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=> d 143 1-22 ibib ed abs hitstr hitind
L43 ANSWER 1 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN
ACCESSION NUMBER:
                          2006:680329 HCAPLUS
DOCUMENT NUMBER:
                          145:125295
TITLE:
                          Glycidyl-containing triazines derivatives for
                          compounding with epoxy regins
INVENTOR(S):
                          Miyauchi, Yukio
PATENT ASSIGNEE(S):
                          Shikoku Chemicals Corp/, Japan
                          Jpn. Kokai Tokkyo Kohø, 7 pp.
SOURCE:
                          CODEN: JKXXAF
DOCUMENT TYPE:
                          Patent
LANGUAGE:
                          Japanese
FAMILY ACC. NUM. COUNT:
PATENT INFORMATION:
     PATENT NO.
                                 DATE
                          KIND
                                             APPLICATION NO.
                                                                     DATE
     JP 2006182834
                           Α
                                 20060713
                                             JP 2004-375621
                                                                     20041227
PRIORITY APPLN. INFO.:
                                             JP 2004-375621
                                                                     20041227
OTHER SOURCE(S):
                          MARPAT
                                 145:125295
     Entered STN:
ED
                   14 Jul 2008
GI
```

The invention relates to triazine derivs. I [R = CH2CHOHCH2OQCMe2Q(OCH2CHOHCH2OQCMe2Q)mOGly; Q = p-phenylene; m = 0-2; n = 1-3]. The triazine derivs. show good compatibility to epoxy resins and work as curing agents to provide epoxy resins with good transparency and heat and weather resistance. Thus, tris(3-carboxypropyl)isocyanurate was reacted with bisphenol A epoxy resin (Epikote 828) to give I (m = 0, n = 3).

IT 897387-55-2P

Ι

897387-55-2P
 (glycidyl-containing triazines for epoxy resin crosslinkers with good compatibility)

RN 897387-55-2 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tributanoic acid, 2,4,6-trioxo-, tris[2-hydroxy-3-[4-[1-methyl-1-[4-(oxiranylmethoxy)phenyl]ethyl]pheno xy]propyl] ester (9CI) (CA INDEX NAME)

PAGE 1-A

PAGE 1-B

PAGE 1-C

$$-cH_2$$

PAGE 2-B

IT 319017-31-7

(glycidyl-containing triazines for epoxy resin crosslinkers with good compatibility)

RN 319017-31-7 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tributanoic acid, 2,4,6-trioxo- (9CI) (CA INDEX NAME)

CC 37-6 (Plastics Manufacture and Processing)

IT 897387-55-2P

(glycidyl-containing triazines for epoxy resin crosslinkers with good compatibility)

IT 25068-38-6, Epikote 828 319017-31-7

(glycidyl-containing triazines for epoxy resin crosslinkers with good compatibility)

L43 ANSWER 2 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 2005:1153322 HCAPLUS

DOCUMENT NUMBER: 143:430027

TITLE: Antireflecting film for photoresist layer in

photolithography

INVENTOR(S):
Kishioka, Takahiro

PATENT ASSIGNEE(S): Nissan Chemical Industries, Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 20 pp.

CODEN: JKXXAF

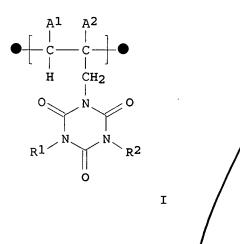
DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1
PATENT INFORMATION:

PATENT NO. KIND DATE APPLICATION NO. DATE

JP 2005300825 A 20051027 JP 2004-115391 20040409
PRIORITY APPLN. INFO.: JP 2004-115391 20040409

ED Entered STN: 28 Oct 2005 GI



AB The title composition contains a polymer in a solvent, wherein the polymer has a repeating unit I(A1-2 = H, Me, ethyl; R1-2= H, C1-6 = alkyl, C3-6 = alkenyl, benzyl, etc.). The film generates little intermixing with a photoresist.

IT 311810-13-6DP, crosslinked 868057-84-5DP, crosslinked

(antireflecting film for photoresist layer in photolithog.)

RN 311810-13-6 H¢APLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, homopolymer (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline \\ O \\ CH_2-N \\ \hline \\ O \\ \end{array}$$

RN 868057-84-5 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-propenyl)-, homopolymer (9CI) (CA INDEX NAME)

CRN 3030-60-2 CMF C6 H7 N3 O3

:

 $CH_2 - CH = CH_2$

IC

ICM G03F007-11 ICS C08F026-06; C09D005-00; C09D139-04; H01L021-027

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 37

ΙT 65-85-0DP, Benzoic acid, reaction product with allyl isocyanurate polymer 311810-13-6DP, crosslinked 868057-84-5DP, crosslinked 868057-86-7DP, crosslinked

(antireflecting film for photoresist layer in photolithog.)

L43 ANSWER 3 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

2005:1130913 HCAPLUS 143:413507

DOCUMENT NUMBER: TITLE:

Antireflection film for semiconductor containing

condensation-type polymer

INVENTOR(S):

Kishioka, Takahiro; Sakamoto, Rikimaru; Hiroi, Yoshiomi; Maruyama, Daisuke

PATENT ASSIGNEE(S):

Nissan Chemical Industries, Ltd., Japan

SOURCE:

PCT Int. Appl., 59 pp. CODEN: PIXXD2

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND DATE	APPLICATION NO.	DATE
		*	
WO 2005098542	A1 20051020	WO 2005-JP6785	20050406
W: AE, AG, AL,	AM, AT, AU, AZ,	BA, BB, BG, BR, BW,	BY, BZ, CA,
CH, CN, CO,	CR, CU, CZ,/DE,	DK, DM, DZ, EC, EE,	EG, ES, FI,
GB, GD, GE,	GH, GM, HR, HU,	ID, IL, IN, IS, JP,	KE, KG, KM,
KP, KR, KZ,	LC, LK, LR, LS,	LT, LU, LV, MA, MD,	MG, MK, MN,
		OM, PG, PH, PL, PT,	
SD, SE, SG,	SK, SL, SM, SY,	TJ, TM, TN, TR, TT,	TZ, UA, UG,
US, UZ, VC,	VN, YU, ZA, ZM,	ZW	
RW: BW, GH, GM,	KE, LS, MW, MZ,	NA, SD, SL, SZ, TZ,	UG, ZM, ZW,
		TJ, TM, AT, BE, BG,	
		GR, HU, IE, IS, IT,	
		TR, BF, BJ, CF, CG,	
GN, GQ, GW,	ML, MR, NE, SM,	TD, TG	
EP 1757986	A1 - 20070228	EP 2005-728797	20050406
R: DE, FR, GB,	IT, NL		
CN 1965268	A 200/10516	CN 2005-80018731	20050406
PRIORITY APPLN. INFO.:	/ ,	JP 2004-115385	A 20040409
	/ `	`.	
	/		

WO 2005-JP6785

W 20050406

ED Entered STN: 21 Oct 2005

AB To provide an antireflection film that exhibits as high light reflection preventing effect, being free from intermixing with photoresist, and that can be employed in a lithog. process using irradiation beam, such as those from ArF excimer laser and F2 excimer laser, and further to provide a composition for forming such an antireflection film. There is provided an antireflection film forming a composition characterized by containing a polymer having a pyrimidine trione structure, imidazolidinedione structure, imidazolidinetrione structure or triazinetrione structure and containing a solvent.

IT 867300-29-6P 867300-30-9P 867300-31-0P 867300-34-3P 867300-36-5P 867300-39-8P 867300-40-1P 867300-41-2P 867300-42-3P 867300-43-4P 867330-22-1P

(preparation of antireflection films for semiconductor containing condensation-type polymer)

RN 867300-29-6 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with 5,5-diethyl-2,4,6(1H,3H,5H)-pyrimidinetrione (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline \\ O \\ CH_2-N \\ O \\ \end{array}$$

CM 2

CRN 57-44-3 CMF C8 H12 N2 O3

RN 867300-30-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with 5-ethyl-5-phenyl-2,4,6(1H,3H,5H)-pyrimidinetrione (9CI) (CA INDEX NAME)

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c}
 & CH_2 - CH = CH_2 \\
 & N & O \\
 & N & CH_2 - O
\end{array}$$

CM 2

CRN 50-06-6 CMF C12 H12 N2 O3

RN 867300-31-0 HCAPLUS

CN 1,4-Benzenedicarboxylic acid, bis(oxiranylmethyl) ester, polymer with 1-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 7195-44-0 CMF C14 H14 O6

CM 2

RN 867300-34-3 HCAPLUS

CN 1,2-Benzenedicarboxylic acid, bis(oxiranylmethyl) ester, polymer with 1-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 7195-45-1 CMF C14 H14 O6

CM 2

CRN 3030-60-2 CMF C6 H7 N3 O3

RN 867300-36-5 HCAPLUS

CN 1,3-Benzenedicarboxylic acid, bis(oxiranylmethyl) ester, polymer with 1-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 7195-43-9 CMF C14 H14 O6

CRN 3030-60-2 CMF C6 H7 N3 O3

RN 867300-39-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with 5,5-diethyl-2,4,6(1H,3H,5H)-pyrimidinetrione and 2,2'-[1,2-ethanediylbis(oxymethylene)]bis[oxirane] (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

CM 2

CRN 2224-15-9 CMF C8 H14 O4

CM 3

CRN 57-44-3 CMF C8 H12 N2 O3

RN 867300-40-1 HCAPLUS

CN 1,4-Benzenedicarboxylic acid, polymer with 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline O & N & O \\ \hline CH_2-N & N-CH_2 \\ \hline O & O \\ \hline \end{array}$$

CM 2

CRN 100-21-0 CMF C8 H6 O4

RN 867300-41-2 HCAPLUS

CN 1,4-Benzenedicarboxylic acid, polymer with 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione and 2,2'-[1,4-butanediylbis(oxymethylene)]bis[oxirane] (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2\\ \hline O\\ N\\ O\\ CH_2-N\\ N-CH_2 \end{array}$$

CRN 2425-79-8 CMF C10 H18 O4

CM 3

CRN 100-21-0 CMF C8 H6 O4

RN 867300-42-3 HCAPLUS

CN 1,4-Benzenedicarboxylic acid, bis(oxiranylmethyl) ester, polymer with 2,2'-[1,4-butanediylbis(oxymethylene)]bis[oxirane] and 1-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 7195-44-0 CMF C14 H14 O6

CM 2

CRN 2425-79-8 CMF C10 H18 O4

RN 867300-43-4 HCAPLUS

CN 1,4-Benzenedicarboxylic acid, bis(oxiranylmethyl) ester, polymer with 2,2'-[1,6-hexanediylbis(oxymethylene)]bis[oxirane] and 1-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 16096-31-4 CMF C12 H22 O4

CM 2

CRN 7195-44-0 CMF C14 H14 O6

CM 3

$$\begin{array}{c|c}
 & H & O \\
 & H & N & CH_2 - CH = CH_2
\end{array}$$

RN 867330-22-1 HCAPLUS

CN 1,4-Benzenedicarboxylic acid, bis(oxiranylmethyl) ester, polymer with bis(oxiranylmethyl) 1,2-cyclohexanedicarboxylate and 1-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 7195-44-0 CMF C14 H14 O6

CM 2

CRN 5493-45-8 CMF C14 H20 O6

CM 3

$$\begin{array}{c|c}
 & H & O \\
 & H & N & O \\
 & CH_2 - CH = CH_2
\end{array}$$

```
IC
     ICM G03F007-11
     ICS C08L079-04; C09D163-00; C09D179-04; H01L021-027
CC
     74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other
     Reprographic Processes)
     Section cross-reference(s): 38, 73, 76
TT
     867300-29-6P 867300-30-9P 867300-31-0P
                     867300-33-2P 867300-34-3P
     867300-32-1P
                                                    867300-35-4P
     867300-36-5P
                    867300-37-6P
                                    867300-38-7P
     867300-39-8P 867300-40-1P 867300-41-2P
     867300-42-3P 867300-43-4P 867330-22-1P
     867330-23-2P 867330-24-3P
                                    867330-25-4P
         (preparation of antireflection films for semiconductor containing
        condensation-type polymer)
REFERENCE COUNT:
                                 THERE ARE 8 CITED REFERENCES AVAILABLE FOR
                                 THIS RECORD. ALL CITATIONS AVAILABLE IN THE
                                 RE FORMAT
L43 ANSWER 4 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN
ACCESSION NUMBER:
                           2004:872885 HCAPLUS
DOCUMENT NUMBER:
                           141:372751
TITLE:
                           Composition for formation of underlayer film for
                           lithography containing epoxy compound and
                           carboxylic acid compound
INVENTOR(S):
                           Kishioka, Takahiro
PATENT ASSIGNEE(S):
                           Nissan Chemical Industries, Ltd., Japan
SOURCE:
                           PCT Int. Appl., 43 pp.
                           CODEN: PIXXD2
DOCUMENT TYPE:
                           Patent
LANGUAGE:
                           Japanese
FAMILY ACC. NUM. COUNT:
                          1
PATENT INFORMATION:
     PATENT NO.
                          KIND
                                  DATE
                                               APPLICATION NO.
                                                                        DATE
                          ----
                                  ----
                                               ______
     WO 2004090640
                           A1
                                  2004/021
                                             WO 2004-JP4764
                                                                        20040401
         W: AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA,
              CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI,
              GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW,
              MX, MZ, NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD,
              SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ,
              VC, VN, YU, ZA, ZM, ZW
         RW: BW, GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW, AM, AZ, BY, KG, KZ, MD, RU, TJ, TM, AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PL, PT,
              RO, SE, SI, SK, TR, BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW,
              ML, MR, NE, SN, TD, TG,
     EP 1617289
                                  20060118
                                             EP 2004-725145
                           A1
                                                                        20040401
         R: AT, BE, CH, DE, DK, ES, FR, GB, GR, IT, LI, LU, NL, SE, MC,
              PT, IE, SI, LT, LV, FI, RO, MK, CY, AL, TR, BG, CZ, EE, HU,
              PL, SK, HR
                                  2006/0503
     CN 1768306
                                               CN 2004-80009217
                                                                        20040401
                                                                       20050929
     US 2006234156
                            A1
                                  20061019
                                               US 2005-551130
PRIORITY APPLN. INFO.:
                                               JP 2003-99228
                                                                     A 20030402
                                               WO 2004-JP4764
                                                                     W 20040401
```

ED Entered STN: 21 Oct 2004

AB A composition for formation of underlayer film for lithog. that is used in

the lithog. process for producing semiconductor devices; and an underlayer film exhibiting a dry etching rate greater than in the use of photoresists. In particular, a composition for formation of underlayer film, capable of forming an underlayer film without the need to use a crosslinking reaction catalyzed by a strong acid, which composition comprises a component having epoxy group (polymeric compound or compound) and a component having phenolic hydroxyl group, carboxyl group, protected carboxyl group or acid anhydride structure (polymeric compound or compound).

IT 2451-62-9, Tris(2,3-epoxypropyl)isocyanurate 2904-41-8

, Tris(2-carboxyethyl)isocyanurate

(composition for formation of underlayer film for lithog. containing epoxy compound and carboxylic acid compound)

RN 2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

$$CH_2$$
 N
 CH_2
 CH_2
 CH_2

RN 2904-41-8 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tripropanoic acid, 2,4,6-trioxo- (CA INDEX NAME)

IC ICM G03F007-11

ICS C08G059-40; H01L021-027

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 76

IT 2451-62-9, Tris(2,3-epoxypropyl)isocyanurate 2904-41-8

, Tris(2-carboxyethyl)isocyanurate 9003-01-4, Poly(acrylic acid) (composition for formation of underlayer film for lithog. containing epoxy compound and carboxylic acid compound)

REFERENCE COUNT:

THERE ARE 34 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L43 ANSWER 5 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

```
ACCESSION NUMBER:
                           2004:333974 HCAPLUS
DOCUMENT NUMBER:
                           140:365660
TITLE:
                           Composition for forming antireflection film for
                           lithography
INVENTOR(S):
                           Kishioka, Takahiro; Mizusawa, Ken-ichi; Enomoto,
                           Tomoyuki; Sakamoto, Rikimaru; Nakayama, Keisuke;
                           Kawamura, Yasuo
PATENT ASSIGNEE(S):
                           Nissan Chemical Industries, Ltd., Japan
                           PCT Int. Appl., 85 pp.
SOURCE:
                           CODEN: PIXXD2
DOCUMENT TYPE:
                           Patent
LANGUAGE:
                           Japanese
FAMILY ACC. NUM. COUNT:
PATENT INFORMATION:
     PATENT NO.
                           KIND
                                  DATE
                                               APPLICATION NO.
                                                                       DATE
      ------
                           ----
                                              WO 2003-JP12875
     WO 2004034148
                           A1
                                  20040422
                                                                       20031008
         W: AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH,
              CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KR, KZ,
              LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK,
              SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU,
              ZA, ZM, ZW
         RW: GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW, AM, AZ,
              BY, KG, KZ, MD, RU, TJ, TM, AT, BE, BG, CH, CY, CZ, DE, DK,
              EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE,
              SI, SK, TR, BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR,
              NE, SN, TD, TG
     AU 2003271123
                            A1
                                 -20040504
                                              AU 2003-271123
                                                                       20031008
     EP 1560070
                           A1
                                  20050803
                                              EP 2003-751376
                                                                       20031008
             AT, BE, CH, DE, DK, ES, FR, GB, GR, IT, LI, LU, NL, SE, MC,
              PT, IE, SI, LT, LV, FI, RO, MK, CY, AL, TR, BG, CZ, EE, HU, SK
     CN 1723418
                                  20060118
                                               CN 2003-80105388
                           Α
                                                                       20031008
                                               JP 2002-295777
PRIORITY APPLN. INFO.:
                                                                    A 20021009
                                               JP 2003-126886
                                                                    A 20030502
                                               WO 2003-JP12875
                                                                    W 20031008
ED
     Entered STN: 23 Apr 2004
AB
     A composition for forming an antireflection film comprises a compound, an
     oligomer or a polymer comprising a triazine-trione moiety having a
     hydroxyalkyl structure as a substitute on a nitrogen atom. The composition
     can provide an antireflection film which exhibits good absorptivity
     for a light having a wavelength suitable for use in the production of a
     semiconductor device, has high antireflection effect, and exhibits a
     dry etching rate greater than that of a photoresist layer.
IT
     681440-09-5P 681440-10-8P 681440-11-9P
     681440-12-0P 681440-14-2P 681440-16-4P
     681440-19-7P
         (oligomeric; photolithog antireflective film compns. containing)
RN
     681440-09-5 HCAPLUS
CN
     2-Naphthalenecarboxylic acid, 6-hydroxy-, polymer with
     1,3,5-tris(oxiranylmethyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI)
```

(CA INDEX NAME)

CRN 16712-64-4 CMF C11 H8 O3

CM 2

CRN 2451-62-9 CMF C12 H15 N3 O6

RN 681440-10-8 HCAPLUS

CN Benzoic acid, 2,4,6-tribromo-3-hydroxy-, polymer with 1,3,5-tris(oxiranylmethyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 14348-40-4 CMF C7 H3 Br3 O3

CM 2

CRN 2451-62-9 CMF C12 H15 N3 O6

RN

681440-11-9 HCAPLUS
Benzoic acid, 2-hydroxy-3,5-diiodo-, polymer with 1,3,5-CN tris(oxiranylmethyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 2451-62-9 CMF C12 H15 N3 O6

CM 2

CRN 133-91-5 CMF C7 H4 I2 O3

RN681440-12-0 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2propenyl) -, polymer with 1-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)trione (9CI) (CA INDEX NAME)

CM1 CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline O & N & O \\ \hline CH_2-N & N-CH_2 \\ \hline \end{array}$$

CM 2

CRN 3030-60-2 CMF C6 H7 N3 O3

RN 681440-14-2 HCAPLUS CN 1,3,5-Triazine-2,4,6

1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with 1-phenyl-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH \longrightarrow CH_2 \\ \hline O & N & O \\ \hline CH_2-N & N-CH_2 \\ \hline O & O \\ \end{array}$$

CM 2

CRN 5725-46-2 CMF C9 H7 N3 O3

RN 681440-16-4 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with 1-methyl-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$CH_2-CH = CH_2$$

$$O \qquad N \qquad O$$

$$CH_2 - N \qquad N - CH_2$$

CM 2

CRN 6726-47-2 CMF C4 H5 N3 O3

$$\begin{array}{c|c}
 & H & O \\
 & N & N \\
 & HN & N \\
 & O & Me
\end{array}$$

RN 681440-19-7 HCAPLUS

CN 1,3,5-Triazine-1,3(2H,4H)-dibutanoic acid, dihydro-5-methyl-2,4,6-trioxo-, polymer with 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CRN 681440-18-6 CMF C12 H17 N3 O7

CRN 69731-45-9 CMF C12 H15 N3 O5

IT 681440-23-3P

(photolithog antireflective film compns. containing)

RN 681440-23-3 HCAPLUS

2-Naphthalenecarboxylic acid, 3,7-dihydroxy-, polymer with 1,3,5-tris(oxiranylmethyl)-1,3,5-triazine-2,4,6(1H,3H,5H)-trione (9CI) (CA INDEX NAME)

CM 1

CN

CRN 83511-07-3 CMF C11 H8 O4

CM 2

CRN 2451-62-9 CMF C12 H15 N3 O6

IT 2451-62-9, Tris(2,3-epoxypropyl)isocyanurate

(reaction with carboxyalkyldimethylisocyanuric acids in preparation of antireflective coating composition component)

RN 2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

$$\begin{array}{c|c} O & & O & \\ \hline O & CH_2 & & N & CH_2 \\ \hline O & & & \\ \hline & \\ \hline & & \\ \hline & \\ \hline & \\ \hline & \\ \hline & & \\ \hline &$$

IT 681440-24-4 681440-25-5

(reaction with tris(2,3-epoxypropyl) isocyanurate in preparation of antireflective coating composition component)

RN 681440-24-4 HCAPLUS

CN 1,3,5-Triazine-1(2H)-butanoic acid, tetrahydro-3,5-dimethyl-2,4,6-trioxo- (9CI) (CA INDEX NAME)

RN 681440-25-5 HCAPLUS

CN 1,3,5-Triazine-1(2H)-acetic acid, tetrahydro-3,5-dimethyl-2,4,6-trioxo-(9CI) (CA INDEX NAME)

```
Me CH<sub>2</sub>-CO<sub>2</sub>H
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IC ICM G03F007-11

ICS H01L021-027

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 76

IT 681440-09-5P 681440-10-8P 681440-11-9P

681440-12-0P 681440-13-1P 681440-14-2P

681440-15-3P **681440-16-4P** 681440-17-5P

681440-19-7P 681440-20-0P

(oligomeric; photolithog antireflective film compns. containing)

IT 681440-21-1P 681440-22-2P 681440-23-3P

(photolithog antireflective film compns. containing)

IT 2451-62-9, Tris(2,3-epoxypropyl)isocyanurate

(reaction with carboxyalkyldimethylisocyanuric acids in preparation of antireflective coating composition component)

IT 681440-24-4 681440-25-5

(reaction with tris(2,3-epoxypropyl) isocyanurate in preparation of antireflective coating composition component)

REFERENCE COUNT:

THERE ARE 7 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L43 ANSWER 6 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 2002:466084 HCAPLUS

DOCUMENT NUMBER: 137:47922

TITLE: Epoxy resins, their manufacture, epoxy resin

compositions, and cured articles

INVENTOR(S): Kaji, Masashi; Ogami, Koichiro

PATENT ASSIGNEE(S): Nippon Steel Chemical Co., Ltd., Japan

SOURCE: PCT Int. Appl., 28 pp.

CODEN: PIXXD2

DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PA	TENT NO.	KIND	DATE	APPLICATION NO.	DATE
WO	2002048235	A1	20020620	WO 2001-JP10798	20011210
	W: CN, JP, KR,	US			
	RW: AT, BE, CH,	CY, DE	, DK, ES, FI	, FR, GB, GR, IE, IT	, LU, MC,
	NL, PT, SE,	TR			
JP	2003176331	A	20030624	JP 2002-212673	20020722
US	2004024167	A1	20040205	US 2003-433365	20030604
US	6903180	B2	20050607		
PRIORIT	Y APPLN. INFO.:			JP 2000-376351	A 20001211
				WO 2001-JP10798	A 20011210

ED Entered STN: 21 Jun 2002

GΙ

The invention relates to novel epoxy resins, and epoxy resin compns. or cured articles produced by using the resins. The cured articles are excellent in flame retardance, adhesion, water vapor resistance, and heat resistance, and suitably usable in lamination, molding, casting, adhesion, or the like. The epoxy resins are represented by the general formula I (Y1 = glycidyloxyarylmethyl group; Y2, Y3 = glycidyl, glycidyloxyarylmethyl group).

IT 436147-29-4P

(preparation of isocyanurate ring-containing epoxy resins)

RN 436147-29-4 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[(4-hydroxy-3,5-dimethylphenyl)methyl]- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\ & & & \\$$

IT 436147-33-0P

(preparation of isocyanurate ring-containing epoxy resins)

RN 436147-33-0 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris[[3,5-dimethyl-4-(oxiranylmethoxy)phenyl]methyl]- (9CI) (CA INDEX NAME)

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IC ICM C08G059-06
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ICS C08G059-32; C08G059-62; C07D405-14

CC 37-3 (Plastics Manufacture and Processing)

Section cross-reference(s): 38

IT 436147-29-4P 436147-30-7P

(preparation of isocyanurate ring-containing epoxy resins)

IT 436147-33-0P

(preparation of isocyanurate ring-containing epoxy resins)

REFERENCE COUNT: 6 THERE ARE 6 CITED REFERENCES AVAILABLE FOR

THIS RECORD. ALL CITATIONS AVAILABLE IN THE

RE FORMAT

L43 ANSWER 7 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

2000:865395 HCAPLUS

DOCUMENT NUMBER:

134:30015

TITLE:

Thermosetting epoxy resin compositions with good

mechanical and electric properties and

processability

INVENTOR(S):

Miyauchi, Yukio; Kang, Naoki

PATENT ASSIGNEE(S):

Shikoku Chemicals Corp., Japan

SOURCE:

Jpn. Kokai Tokkyo Koho, 5 pp. CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 2000344867 JP 3477111	A B2	20001212 20031210	JP 1999-154388	19990601
PRIORITY APPLN. INFO.:			JP 1999-154388	19990601

ED Entered STN: 12 Dec 2000

AB The compns., useful for adhesives, coatings, elec. insulators,

sealants, laminated boards, etc., contain monoallyl diglycidyl isocyanurates and epoxy resin hardeners. Thus, a composition comprising monoallyl diglycidyl isocyanurate and 2E4MZ was cured to give a test piece showing flexural modulus 42,740 kg/cm2, bending strength 1028 kg/cm2, Tg 173°, and volume resistivity 0.92 + 1016 $\Omega\text{-cm}.$

IT 311810-13-6P 311810-14-7P 311810-15-8P 311810-16-9P

(thermosetting epoxy resin compns. containing allyl glycidyl isocyanurate)

RN 311810-13-6 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, homopolymer (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH \longrightarrow CH_2 \\ \hline \\ O & \\ CH_2-N & \\ N-CH_2 \\ \hline \\ O & \\ \end{array}$$

RN 311810-14-7 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with (chloromethyl)oxirane and 4,4'-(1-methylethylidene)bis[phenol] (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline O & N & O \\ \hline CH_2-N & N-CH_2 \\ \hline \end{array}$$

CM 2

CRN 106-89-8 CMF C3 H5 Cl O

CRN 80-05-7 CMF C15 H16 O2

RN 311810-15-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with hexahydromethyl-1,3-isobenzofurandione (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$CH_2-CH = CH_2$$

$$O$$

$$CH_2-N$$

$$N-CH_2$$

CM 2

CRN 25550-51-0 CMF C9 H12 O3 CCI IDS

D1-Me

RN 311810-16-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(oxiranylmethyl)-5-(2-propenyl)-, polymer with (chloromethyl)oxirane, hexahydromethyl-1,3-isobenzofurandione and 4,4'-(1-methylethylidene)bis[phenol] (9CI) (CA INDEX NAME)

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline \\ O \\ CH_2-N \\ \hline \\ O \\ \end{array}$$

CM 2

CRN 25550-51-0 CMF C9 H12 O3 CCI IDS

D1-Me

CM 3

CRN 106-89-8 CMF C3 H5 Cl O

CM 4

CRN 80-05-7 CMF C15 H16 O2

IT 69731-45-9P

> (thermosetting epoxy resin compns. containing allyl glycidyl isocvanurate)

RN69731-45-9 HCAPLUS

1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(2-oxiranylmethyl)-5-(2-CN propen-1-yl) - (CA INDEX NAME)

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline \\ O \\ CH_2-N \\ \hline \\ O \\ \end{array}$$

3030-60-2, Allyl isocyanurate IT

> (thermosetting epoxy resin compns. with good mech. and elec. properties and processability)

RN 3030-60-2 HCAPLUS

CN1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-propenyl)- (9CI) (CA INDEX NAME)

IC ICM C08G059-38

CC 37-6 (Plastics Manufacture and Processing) Section cross-reference(s): 38, 42, 76

IT 311810-13-6P 311810-14-7P 311810-15-8P

311810-16-9P

(thermosetting epoxy resin compns. containing allyl glycidyl isocyanurate)

IT 69731-45-9P

> (thermosetting epoxy resin compns. containing allyl glycidyl isocyanurate)

IT 106-89-8, Epichlorohydrin, reactions 3030-60-2, Allyl

> (thermosetting epoxy resin compns. with good mech. and elec. properties and processability)

ANSWER 8 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

2000:151741 HCAPLUS

DOCUMENT NUMBER:

133:44912

TITLE:

Tris(2-carboxyethyl)isocyanurate (CIC Acid) as

crosslinking agent in coating

AUTHOR (S):

Sakamoto, Yukihiro; Iwasaki, Yoshiya; Nakagi,

Junji

CORPORATE SOURCE:

Process Dev. Team, Shikoku Chemicals Corp., Japan

SOURCE:

Toso to Toryo (2000), 602, 31-34 CODEN: TOTTAJ; ISSN: 0372-0527

PUBLISHER:

Toryo Shuppansha

DOCUMENT TYPE:

Journal; General Review

LANGUAGE:

Japanese

EDEntered STN: 07 Mar 2000

AB A review with 5 refs. on the properties of 2 chemical compds. as crosslinking agents for coatings; one is mentioned in the title and the other bis(2-carboxy Et)isocyanurate (their trade names are CIC Acid and Bis-CIC Acid resp.). Film properties of solvent-soluble coating containing triglycidyl isocyanurate as a base resin with CIC Acid and also of polyepoxide powder coating with a mixture of CIC Acid and dodecanedioic acid are described. CIC Acid derivs. having lower m.ps. are mentioned.

IT 2451-62-9D, Triglycidyl isocyanurate, polymers

(triscarboxyethyl isocyanurate as crosslinking agent in coatings)

RN 2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

2904-41-8, Tris(2-carboxy ethyl) isocyanurate IT

(triscarbox/ethyl isocyanurate as crosslinking agent in coatings)

RN 2904-41-8 HCAPLUS

1,3,5-Triazine-1,3,5(2H,4H,6H)-tripropanoic acid, 2,4,6-trioxo- (CA CN INDEX NAME)

42/-0 (Coatings, Inks, and Related Products) CC

IT 2451-62-9D, Triglycidyl isocyanurate, polymers (triscarboxyethyl isocyanurate as crosslinking agent in coatings)

IT 2904-41-8, Tris(2-carboxy ethyl)isocyanurate
(triscarboxyethyl isocyanurate as crosslinking agent in coatings)

L43 ANSWER 9 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1999:681479 HCAPLUS

DOCUMENT NUMBER:

131:300634

TITLE:

SOURCE:

Fire-resistant epoxy coating compositions

INVENTOR(S):

Sakamoto, Yukihiro; Hasebe, Akihisa; Nakagi, Junji

PATENT ASSIGNEE(S):

Shikoku Chemicals Corp., Japan Jpn. Kokai Tokkyo Koho, 5 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE	
JP 11293189	A	19991026	JP 1998-101617	19980414	
PRIORITY APPLN. INFO.:			JP 1998-101617	19980414	

ED Entered STN: 27 Oct 1999

Title compns., with good curability and providing colorless and transparent coatings with good adhesion to metal substrate, comprise an epoxy resin having >2 epoxy groups, 1,3,5-tris(2-carboxyethyl)isocyanurate, 1-50 weight% (based on the total weight of the epoxy resin and the isocyanurate) of non-halogen phosphoric acid esters, and 10-500 weight% (based on the total weight of rest of the components) an organic solvent with solubility parameter of 8.0-13.0. The equivalent ratio of the epoxy group in the epoxy resin to the carboxy group in the isocyanurate is in the range of 0.5-4.0.

IT 2904-41-8, 1,3,5-Tris(2-carboxyethyl) isocyanurate

(fire-resistant epoxy/coating compns.)

RN 2904-41-8 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tripropanoic acid, 2,4,6-trioxo- (CA INDEX NAME)

IT 28825-96-9, TEPIC S

(fire-resistant epoxy coating compns.)

RN 28825-96-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-, homopolymer (CA INDEX NAME)

CM 1

CRN 2451-62-9 CMF C12 H15 N3 O6

IC ICM C09D163-06

ICS C08G059-42; C07D251-34

CC 42-9 (Coatings, Inks, and Related Products)

IT 512-56-1, Trimethyl phosphate 2904-41-8,

1,3,5-Tris(2-carboxyethyl)isocyanurate
 (fire-resistant epoxy coating compns.)

IT 28825-96-9, TEPIC S

(fire-resistant epoxy coating compns.)

L43 ANSWER 10 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1999:680219 HCAPLUS

DOCUMENT NUMBER:

131:300633

TITLE:

Epoxy resin coating compositions with good curability at relatively low temperature and

adhesion to metal surface

INVENTOR (S):

Sakamoto, Yukihiro; Hasebe, Akihisa; Nakaki, Junji

PATENT ASSIGNEE(S):

Shikoku Chemicals Corp., Japan Jpn. Kokai Tokkyo Koho, 3 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

SOURCE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE	
	- 				
JP 11293187	Α	19991026	JP 1998-100922	19980413	
PRIORITY APPLN. INFO.:			JP 1998-100922	19980413	

ED Entered STN: 26 Oct 1999

AB The compns. giving cured coat films with good transparency, comprise (A) epoxy resins bearing ≥2 epoxy groups, (B) 1,3,5-tris(2-carboxyethyl) isocyanurate (I) as curing agent, and organic solvents having solubility parameter 8.0-13.0 at the epoxy group/COOH (of I) equivalent ratio of 0.5-4.0:1 and solvent content 10-500% based on A+B. Thus, a composition of TEPIC-S (isocyanurate-type epoxy resin) 100, I 50, and DMF 200 parts showed gel time 40 s and pot life 4 days.

IT 2904-41-8, 1,3,5-Tris(2-carboxyethyl) isocyanurate

(curing agents; epoxy resin coating compns. with good curability at relatively low temperature and adhesion to metal surface)

RN 2904-41-8 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tripropanoic acid, 2,4,6-trioxo- (CA INDEX NAME)

Patent

Japanese

DOCUMENT TYPE:

FAMILY ACC. NUM. COUNT: PATENT INFORMATION:

LANGUAGE:

PATENT NO. KIND DATE APPLICATION NO. DATE _____ _ _ _ _ -----------JP 10316665 Α· 19981202 JP 1997-137703 19970513 PRIORITY APPLN. INFO.: JP 1997-137703 19970513

OTHER SOURCE(S):

CASREACT 130:38406

ED Entered STN: 08 Dec 1998

AB Glycidyl allyl isocyanurates, useful as curing agents for polymers (no data), are prepared by reaction of monoallyl isocyanurates or diallyl isocyanurates with 4-18 mol equivalent of epichlorohydrin in the presence of 0.005-0.15 mol equivalent of phase-transfer catalysts and 0.5-5 mol equivalent of H2O and epoxidn. of 3-chloro-2-hydroxypropyl group-containing isocyanurates. Epichlorohydrin (499.5 g) was added with 94.0 g diallyl isocyanurate in the presence of 40.5 g H2O and 4.5 g Me4NBr at 88-119° for 1.5 h and epoxidized with NaOH at ≤40° for 1 h to give 96.3% monoglycidyl diallyl isocyanurate.

IT 20395-16-8P 69731-45-9P

(preparation of substituted isocyanurates by addition of isocyanurate with epichlorohydrin using phase-transfer catalysts and epoxidn.)

RN 20395-16-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-1(2-oxiranylmethyl)-3,5-di-2-propen-1-yl- (CA INDEX NAME)

$$\begin{array}{c|c} CH_2-CH \longrightarrow CH_2 \\ \hline O & & \\ \hline O & \\ CH_2-CH \longrightarrow CH_2 \\ \hline O & \\ CH_2-CH \longrightarrow CH_2 \\ \hline \end{array}$$

RN 69731-45-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(2-oxiranylmethyl)-5-(2-propen-1-yl)- (CA INDEX NAME)

$$\begin{array}{c|c} CH_2-CH \longrightarrow CH_2 \\ \hline \\ O \\ CH_2-N \\ \hline \\ O \\ \end{array}$$

IT 3030-60-2

(preparation of substituted isocyanurates by addition of isocyanurate with epichlorohydrin using phase-transfer catalysts and epoxidn.)

RN 3030-60-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-propenyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c}
 & H & O \\
 & H & N & CH_2 - CH = CH_2
\end{array}$$

IC ICM C07D251-34

ICS C07D251-34

CC 28-18 (Heterocyclic Compounds (More Than One Hetero Atom))

IT 20395-16-8P 69731-45-9P

> (preparation of substituted isocyanurates by addition of isocyanurate with epichlorohydrin using phase-transfer catalysts and epoxidn.)

IT 6294-79-7, Diallyl isocyanurate

(preparation of substituted isocyanurates by addition of isocyanurate with epichlorohydrin using phase-transfer catalysts and epoxidn.)

L43 ANSWER 12 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1998:758661 HCAPLUS

130:52860 DOCUMENT NUMBER:

TITLE: Fluorine-containing graft polymers with good

adhesion and their manufacture

INVENTOR(S): Kanno, Fukuo; Sato, Takashi; Yokota, Masataka;

Kato, Yuichi

PATENT ASSIGNEE(S): Asahi Glass Co., Ltd., Japan; Nippon Kasei

Chemical Co., Ltd.

SOURCE: Jpn. Kokai Tokkyo Koho, 6 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE	
JP 10310615	Α	19981124	JP 1997-137457	19970513	
PRIORITY APPLN. INFO.:			JP 1997-137457	19970513	

ED Entered STN: 03 Dec 1998

AB Title polymers are obtained by grafting allyl glycidyl isocyanurates onto F-containing polymers containing H bonded with C of the main chain. polymers are manufactured by melt-blending the F-containing polymers, the isocyanurates, and radical generators at the temperature where radicals are generated. Thus, Aflon COP LM 740 (ethylene-tetrafluoroethylene copolymer), monoglycidyl diallyl isocyanurate (prepared from epichlorohydrin and diallyl isocyanurate), and dicumyl peroxide were melt-blended, extruded, and pelletized to give graft copolymer pellets showing melt index 4 g/10 min. Then, the pellets were extruded to give film showing wetting index 34 dyne/cm and adhesion strength to flexible poly(vinyl chloride) sheet 1.5 kg/cm.

IT 20395-16-8P 69731-45-9P

> (in preparation of allyl glycidyl isocyanurates for fluoropolymer grafting)

RN 20395-16-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-oxiranylmethyl)-3,5-di-2propen-1-yl- (CA INDEX NAME)

$$\begin{array}{c|c} CH_2-CH = CH_2 \\ \hline \\ O \\ \hline \\ CH_2-CH = CH_2 \\ \hline \\ O \\ CH_2-CH = CH_2 \\ \hline \\ O \\ \end{array}$$

RN 69731-45-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(2-oxiranylmethyl)-5-(2-propen-1-yl)- (CA INDEX NAME)

$$\begin{array}{c|c} CH_2-CH = CH_2 \\ \hline O & N & O \\ \hline CH_2-N & N-CH_2 \\ \hline O & O \\ \end{array}$$

IT 3030-60-2, Allyl isocyanurate

(in preparation of allyl glycidyl isocyanurates for fluoropolymer grafting)

RN 3030-60-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-propenyl)- (9CI) (CA INDEX NAME)

IT 216859-14-2P 217456-60-5P

(preparation of F-containing polymers grafted with allyl glycidyl isocyanurates)

RN 216859-14-2 HCAPLUS

CM 1

CRN 69731-45-9 CMF C12 H15 N3 O5

$$\begin{array}{c|c} CH_2-CH=CH_2 \\ \hline O & N & O \\ \hline CH_2-N & N-CH_2 \\ \hline \end{array}$$

CM 2

CRN 116-14-3 CMF C2 F4

CM 3

CRN 74-85-1 CMF C2 H4

$H_2C = CH_2$

RN 217456-60-5 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(oxiranylmethyl)-3,5-di-2-propenyl-, polymer with ethene and tetrafluoroethene, graft (9CI) (CA INDEX NAME)

CM 1

CRN 20395-16-8 CMF C12 H15 N3 O4

$$CH_2-CH=CH_2$$
 O
 $CH_2-CH=CH_2$
 $CH_2-CH=CH_2$
 $CH_2-CH=CH_2$

CM 2

CRN 116-14-3 CMF C2 F4 F F | | F- C C C F

CM 3

CRN 74-85-1 CMF C2 H4

 $H_2C = CH_2$

IC ICM C08F259-08

CC 35-8 (Chemistry of Synthetic High Polymers)

IT 20395-16-8P 69731-45-9P

(in preparation of allyl glycidyl isocyanurates for fluoropolymer grafting)

IT 106-89-8, Epichlorohydrin, reactions 3030-60-2, Allyl

isocyanurate 6294-79-7, Diallyl isocyanurate

(in preparation of allyl glycidyl isocyanurates for fluoropolymer grafting)

IT 216859-14-2P 217456-60-5P

(preparation of F-containing polymers grafted with allyl glycidyl isocyanurates)

L43 ANSWER 13 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1998:600079 HCAPLUS

DOCUMENT NUMBER:

129:261405

TITLE:

Polyester compositions with good draw-down, impact, heat, and chemical resistances and high

transparency and gloss

INVENTOR (S):

Tokumizu, Shin; Yoshida, Atsushi; Fujimoto, Masaji

PATENT ASSIGNEE(S):

Mitsubishi Rayon Co., Ltd., Japan Jpn. Kokai Tokkyo Koho, 6 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

SOURCE:

Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 10245478	A	19980914	JP 1997-49131	19970304
PRIORITY APPLN. INFO.:			JP 1997-49131	19970304

ED Entered STN: 22 Sep 1998

GI

AB Title compns., useful for hollow containers, direct blow moldings, sheets, films, etc., comprise (A) 97-99.99% polyesters [intrinsic viscosity [η; at 25° in phenol/tetrachloroethane (1/1) mixture] ≥0.5 dL/g] prepared from (a1) acid components containing 80-100 mol% aromatic dicarboxylic acids and their ester-formable derivs. and (a2) glycol components and (B) 0.01-3% isocyanuric acid derivs. I [R = glycidyl, R'H, R'CO2H; R' = methylene, C2-4 alkylene, (C2H4O)n n = 1-8]. Thus, a composition containing a polyester (prepared from 100 mol parts

terephthalic acid and 120 mol parts ethylene glycol; $\eta=0.80\,$ dL/g) and 0.02% (based on the polyester) 1,3,5-tris(2-hydroxyethyl)-isocyanurate was molded into a sheet, which showed good draw-down, impact, heat, and chemical resistances, transparency, and gloss.

IT 2451-62-9 2904-41-8, 1,3,5-Tris(2-carboxyethy1)
isocyanurate

(isocyanurate-containing polyester compns. with good draw-down, impact, heat, and chemical resistances, transparency, and gloss)

RN 2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

$$\begin{array}{c|c}
CH_2 & N & CH_2 \\
\hline
CH_2 & CH_2
\end{array}$$

RN 2904-41-8 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tripropanoic acid, 2,4,6-trioxo- (CA INDEX NAME)

IC ICM C08L067-03 ICS C08K005-3477

CC 37-6 (Plastics Manufacture and Processing)

IT 839-90-7, 1,3,5-Tris(2-hydroxyethyl) isocyanurate 2451-62-9 2904-41-8, 1,3,5-Tris(2-carboxyethyl) isocyanurate

213608-03-8, 1,3,5-Tris(hydroxybutyl) isocyanurate

(isocyanurate-containing polyester compns. with good draw-down, impact, heat, and chemical resistances, transparency, and gloss)

L43 ANSWER 14 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1997:365821 HCAPLUS

DOCUMENT NUMBER:

127:18450

TITLE:

Stabilized fire-resistant poly(alkylene

terephthalate) compositions with excellent heat

and thermal discoloration resistance

INVENTOR(S):

Tsukahara, Yoshimitsu; Ihara, Hisaji; Akitsu,

Masaharu; Kubo, Michihiro

PATENT ASSIGNEE(S):

Sankyo Organic Chemicals Co., Japan

SOURCE:

Jpn. Kokai Tokkyo Koho, 33 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 09077962	Α	19970325	JP 1996-127167	19960522
JP 3414930	B2	20030609		
PRIORITY APPLN. INFO.:			JP 1995-174917 A	19950711

ED Entered STN: 11 Jun 1997

AB The title compns. are formed by adding epoxypropyl isocyanurate and hydrotalcite and/or zeolite to poly(alkylene terephthalate) fireproofed by Br-containing fireproofing agents. A composition from C7000 PBT 100, Fire Guard 7500 20, Sb203 5, triglycidyl isocyanurate 0.6, and hydrotalcite 0.1 part gave an injection molding with slight yellow coloration and degradation time (to brown at 255°) 130 min.

IT 2451-62-9 146692-58-2

(stabilized fire-resistant poly(alkylene terephthalate) compns. with excellent heat and thermal discoloration resistance)

RN 2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

RN 146692-58-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c}
O & H & O \\
\hline
O & CH_2 & N & NH
\end{array}$$

IC ICM C08L067-02

ICS C08K003-26; C08K003-34; C08K005-03; C08K005-3477

CC 37-6 (Plastics Manufacture and Processing)

IT 2451-62-9 12363-58-5 25713-60-4, Pyroguard SR-245

32588-76-4, Saytex BT-93W 52918-26-0, Diglycidyl isocyanurate

146692-58-2 153067-78-8 163797-39-5 163858-94-4

176791-39-2 189643-44-5

(stabilized fire-resistant poly(alkylene terephthalate) compns. with excellent heat and thermal discoloration resistance)

L43 ANSWER 15 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1996:391589 HCAPLUS

DOCUMENT NUMBER:

125:59986

TITLE:

Novel epoxy compounds with triazine ring skeleton

and their manufacture

INVENTOR(S):

Myake, Satoshi; Ikeda, Hisao; Hidaka, Motohiko;

Moro, Takeo

PATENT ASSIGNEE(S):

SOURCE:

Nissan Chemical Ind Ltd, Japan

Jpn. Kokai Tokkyo Koho, 9 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

LANGUAGE:

Patent

E: Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE	
JP 08081461	Α	19960326	JP 1994-217042	19940912	
JP 3368680	B2	20030120			
PRIORITY APPLN. INFO.:			JP 1994-217042	19940912	

OTHER SOURCE(S):

MARPAT 125:59986

ED Entered STN: 09 Jul 1996

AB The epoxy compds. with good workability, giving resins with good weather and heat resistance are manufactured by addition reaction of tri(carboxyalkyl)isocyanurates with epihalohydrins and treating the resulting esters with an alkali substance. Refluxing tri(carboxymethyl)isocyanurate 101, α-epichlorohydrin 625, and Me4N+ Cl-3 g at 100° and adding 120 g 50% NaOH over 3 h while removing the formed water and unreacted reactant gave tri(carboxymethyl)isocyanurate triglycidyl ester (I). I 100, Me humic anhydride 90.5, and DMP 30 3 parts gave a cured resin with glass temperature 195°.

IT 178200-12-9P 178200-13-0P 178200-14-1P

(manufacture of novel epoxy compds. with triazine ring skeleton for resins with good heat and weather resistance)

RN 178200-12-9 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-triacetic acid, 2,4,6-trioxo-, tris(oxiranylmethyl) ester (9CI) (CA INDEX NAME)

RN 178200-13-0 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-triacetic acid, 2,4,6-trioxo-, tris[(2-methyloxiranyl)methyl] ester (9CI) (CA INDEX NAME)

$$\begin{array}{c} O \\ O \\ Me \end{array}$$

$$\begin{array}{c} CH_2 - O - C - CH_2 - N \\ O \\ O \\ CH_2 \\ C \longrightarrow O \\ CH_2 \\ C \longrightarrow O \\ CH_2 \\ C \longrightarrow Me \end{array}$$

RN 178200-14-1 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tripropanoic acid, 2,4,6-trioxo-, tris(oxiranylmethyl) ester (9CI) (CA INDEX NAME)

IT 178200-15-2P 178200-16-3P 178200-17-4P

(manufacture of novel epoxy compds. with triazine ring skeleton for resins with good heat and weather resistance)

RN 178200-15-2 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-triacetic acid, 2,4,6-trioxo-,
 tris(oxiranylmethyl) ester, polymer with (3aα,4β,7β,7a
 α)-3a,4,7,7a-tetrahydromethyl-4,7-methanoisobenzofuran-1,3-dione
 (9CI) (CA INDEX NAME)

CM 1

CRN 178200-12-9 CMF C18 H21 N3 O12

CM 2

CRN 53584-57-9

CMF C10 H10 O3 CCI IDS

D1-Me

RN 178200-16-3 HCAPLUS CN 1,3,5-Triazine-1,3,5(2

1,3,5-Triazine-1,3,5(2H,4H,6H)-triacetic acid, 2,4,6-trioxo-, tris[(2-methyloxiranyl)methyl] ester, polymer with $(3a\alpha,4\beta,7\beta,7a\alpha)$ -3a,4,7,7a-tetrahydromethyl-4,7-methanoisobenzofuran-1,3-dione (9CI) (CA INDEX NAME)

CM 1

CRN 178200-13-0 CMF C21 H27 N3 O12

$$\begin{array}{c} O \\ O \\ O \\ Me \end{array}$$

$$\begin{array}{c} O \\ CH_2 \\ CH_2 \\ C \end{array}$$

$$\begin{array}{c} O \\ N \\ O \\ CH_2 \\ C \end{array}$$

$$\begin{array}{c} O \\ N \\ O \\ CH_2 \\ C \end{array}$$

$$\begin{array}{c} O \\ Me \\ O \\ CH_2 \\ C \end{array}$$

CM 2

CRN 53584-57-9 CMF C10 H10 O3

CCI IDS

D1-Me

RN 178200-17-4 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tripropanoic acid, 2,4,6-trioxo-, tris(oxiranylmethyl) ester, polymer with $(3a\alpha,4\beta,7\beta,7a$ α)-3a,4,7,7a-tetrahydromethyl-4,7-methanoisobenzofuran-1,3-dione (9CI) (CA INDEX NAME)

CM 1

CRN 178200-14-1 CMF C21 H27 N3 O12

CM 2

CRN 53584-57-9 CMF C10 H10 O3 CCI IDS

D1-Me

IT 1968-52-1 2904-41-8

(reaction with epichlorohydrin; manufacture of novel epoxy compds. with triazine ring skeleton for resins with good heat and weather resistance)

RN 1968-52-1 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-triacetic acid, 2,4,6-trioxo- (9CI) (CA INDEX NAME)

RN 2904-41-8 HCAPLUS

CN 1,3,5-Triazine-1,3,5(2H,4H,6H)-tripropanoic acid, 2,4,6-trioxo- (CA INDEX NAME)

IC ICM C07D405-14

ICS C08G059-32

ICI C07D405-14, C07D251-34, C07D303-48

CC 37-3 (Plastics Manufacture and Processing)

Section cross-reference(s): 35

IT 178200-12-9P 178200-13-0P 178200-14-1P

(manufacture of novel epoxy compds. with triazine ring skeleton for resins with good heat and weather resistance)

IT 178200-15-2P 178200-16-3P 178200-17-4P

(manufacture of novel epoxy compds. with triazine ring skeleton for resins with good heat and weather resistance)

IT 1968-52-1 2904-41-8

(reaction with epichlorohydrin; manufacture of novel epoxy compds. with

triazine ring skeleton for resins with good heat and weather resistance)

L43 ANSWER 16 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1993:659565 HCAPLUS

DOCUMENT NUMBER: 119:259565

TITLE: Photopolymerizable composition containing

> interlinked allylic and epoxy polymer network Breeveld, Ricardo Henry; Schutyser, Jan Andre

Jozef

PATENT ASSIGNEE(S): AKZO N. V., Neth.

PCT Int. Appl., 42 pp. SOURCE:

CODEN: PIXXD2

DOCUMENT TYPE:

INVENTOR(S):

Patent English

LANGUAGE: FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
WO 9311465	A1	19930610	WO 1992-EP2332	19921009

RW: AT, BE, CH, DE, DK, ES, FR, GB, GR, IE, IT, LU, MC, NL, SE PRIORITY APPLN. INFO.: EP 1991-203191 A 19911206

Entered STN: 11 Dec 1993 ED

A photopolymerizable composition is described comprising a mixture of AR interpenetrating network-forming monomers and a photoinitiator, the interpenetrating network-forming monomers comprising ethylenically unsatd. compds. capable of forming a polymer network, and a mixture capable of forming an epoxy resin network. The polymer network is formed, at least partially, from allylic compds. Essentially the polymer network and the epoxy resin network are interlinked by means of a compound having both an ethylenically unsatd. functional group and a functional group reactive towards at least one of the ingredients in the epoxy resin network. Preferably, the compound is an ethylenically unsatd. epoxy crosslinker, such as maleic anhydride. The photopolymerizable composition, which optionally further comprises photopolymerizable vinylic monomers, a film-forming binder, solvents, pigments, and other additives, proves particularly useful as an additive plating resist or, if additive catalysts are added, as an electroless platable resist.

IT 2451-62-9 146692-58-2

(photocrosslinkable composition containing)

RN2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

RN 146692-58-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(oxiranylmethyl)- (9CI) (CA INDEX NAME)

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IC ICM G03F007-027

ICS H05K003-18; H05K003-46; C23C018-18

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

IT 101-37-1 108-31-6, 2,5-Furandione, uses 925-21-3 1025-15-6 **2451-62-9** 3990-03-2 9003-35-4D, glycidyl ethers 15625-89-5 24448-20-2 25068-38-6 25550-51-0 42610-22-0

52918-26-0 **146692-58-2**

(photocrosslinkable composition containing)

L43 ANSWER 17 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1993:540514 HCAPLUS

DOCUMENT NUMBER:

119:140514

TITLE:

Heat stabilizers for fire-resistant styrene

polymer compositions

INVENTOR(S):

Tsukahara, Yoshimitsu; Ihara, Hisaji; Yoshimura,

Shigeto

PATENT ASSIGNEE(S):

Sankyo Organic Chemicals Co, Japan

SOURCE:

Jpn. Kokai Tokkyo Koho, 13 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JР 05043757 JР 2742479	A B2	19930223 19980422	JP 1991-202772	19910813
PRIORITY APPLN. INFO.:	D2	19980422	JP 1991-202772	19910813

ED Entered STN: 02 Oct 1993

AB The title compns. comprising styrene polymers, polycarbonates, and Br-containing fireproofing agents are stabilized against thermal degradation by adding phosphate ester metal salts and, optionally, epoxypropyl isocyanurates. A mixture of Toyolac 100 50, Panlite L 1250 50, EBR 700 20, Sb203 3, and Na didecyl phosphate 0.5 part was used to prepare a laminate which was not discolored after 60 min at 265°.

IT 2451-62-9 146692-58-2

(heat stabilizers, for ABS-polycarbonate blends containing fire retardants)

RN 2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

RN 146692-58-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(oxiranylmethyl)- (9CI) (CA INDEX NAME)

IC ICM C08L025-02

ICS C08K005-02; C08K005-3477; C08K005-521; C08L069-00

CC 37-6 (Plastics Manufacture and Processing)

IT 2451-62-9 16686-86-5 51568-80-0 52918-26-0 56624-77-2

109572-94-3 146692-58-2 149991-05-9 149991-06-0

149991-07-1 149991-08-2 149991-09-3 149991-10-6 149991-11-7

149991-12-8 149992-53-0D, boron complexes

(heat stabilizers, for ABS-polycarbonate blends containing fire retardants)

L43 ANSWER 18 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1993:148793 HCAPLUS

DOCUMENT NUMBER: 118:148793

TITLE: Heat-stabilization of flame-resistant

polycarbonate-styrene resin compositions

INVENTOR(S): Tsukahara, Yoshimitsu; Ihara, Hisaji; Yoshimura,

Shigeto

PATENT ASSIGNEE(S): Sankyo Organic Chemicals Co., Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 9 pp.

CODEN: JKXXAF

DOCUMENT TYPE:

Patent

LANGUAGE:

Japanese

FAMILY ACC. NUM. COUNT:

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 04266956	Α	19920922	JP 1991-28158	19910222
PRIORITY APPLN. INFO.:			JP 1991-28158	19910222

OTHER SOURCE(S):

MARPAT 118:148793

Entered STN: 13 Apr 1993 ED

AB The title compns. containing styrene resins, polycarbonates, and bromide fireproofing agents are stabilized by adding ≥1 of epoxypropyl isocyanurate and phosphates (R10) mP(0)(OH)3-m (R1 = alkyl, hydroxyalkyl, alkenyl, aryl, or cycloalkyl; m = 1 or 2). Thus, a composition of Toyolac 100 50, Panlite L1250 50, EBR 700 (epoxy oligomer) 18, Sb2O3 3, mono(epoxypropyl) isocyanurate 0.25, and (C18H37O)2P(O)OH (I) 0.25 part was kneaded at 185° for 3 min, sheeted, and hot pressed in 8 layers at 275° and 5 kg/cm2 to show degradation time 50 min., vs. 30 for a control without I.

IT 2451-62-9 146692-58-2

> (heat stabilizers, for fire-resistant polycarbonate-styrene polymer blends)

RN2451-62-9 HCAPLUS

1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-CN (CA INDEX NAME)

$$CH_2$$
 N
 CH_2
 CH_2
 CH_2

RN 146692-58-2 HCAPLUS

CN1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c}
 & & & H & & O \\
 & & & & & M & & O \\
 & & & & & & & & MH
\end{array}$$

IC ICM C08L025-04

ICS C08K005-02; C08K005-3477; C08K005-52; C08L069-00

37-6 (Plastics Manufacture and Processing) CC

IT 1623-22-9 **2451-62-9** 2627-35-2 2958-09-0 3037-89-6 3115-39-7 21150-89-0 27856-12-8 34332-96-2 42714-99-8 95907-55-4 **146692-58-2** 146692-59-3 52918-26-0 146692-60-6 146692-61-7 146692-62-8 146692-63-9 (heat stabilizers, for fire-resistant polycarbonate-styrene polymer blends)

L43 ANSWER 19 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1993:23139 HCAPLUS

DOCUMENT NUMBER: 118:23139

TITLE: Study of the structure and interaction of

isocyanurates with a mineral filler Kotorlenko, L. A.; Novikova, O. A.

AUTHOR(S): Kotorlenko, L. A.; Novikova, O. A. CORPORATE SOURCE: Inst. Probl. Materialoved., Kiev, USSR

COMPORATE SOURCE: Inst. Probl. Materialoved., Kiev, USSK

SOURCE: Kompozitsionnye Polimernye Materialy (1979-1996?)

(1990), 45, 1-8

CODEN: KPMAD8; ISSN: 0203-3275

DOCUMENT TYPE: Journal LANGUAGE: Russian ED Entered STN: 24 Jan 1993

AB To study the interaction of diallyl isocyanurate derivs. with glass fibers, allyl, hydroxypropyl, epoxypropyl, carboxymethyl, and hydroxyethyl diallyl isocyanates adsorbed on silica gel were studied as a model system by IR spectroscopy. The semipolarity of the carbonyl bonds in the isocyanates was confirmed. Interaction of OH groups of the silica gel surface with the isocyanurate ring was considered. The quality of fiber lubricants based on isocyanuric acid derivs. increased with an increasing number of substituents capable of reaction with OH groups of the surface and increasing interaction.

IT 13915-42-9 20395-16-8, Diallyl epoxypropyl
isocyanurate

(interaction of, with glass fibers, model systems for determination of)

RN 13915-42-9 HCAPLUS

CN 1,3,5-Triazine-1(2H)-acetic acid, tetrahydro-2,4,6-trioxo-3,5-di-2-propenyl- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} CH_2-CH \longrightarrow CH_2 \\ \hline \\ O & N & O \\ \hline \\ HO_2C-CH_2 & CH_2-CH \longrightarrow CH_2 \\ \hline \\ O & CH_2-CH \longrightarrow CH_2 \\ \hline \end{array}$$

RN 20395-16-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-oxiranylmethyl)-3,5-di-2-propen-1-yl- (CA INDEX NAME)

$$CH_2-CH = CH_2$$

$$CH_2-CH = CH_2$$

$$CH_2-CH = CH_2$$

$$CH_2-CH = CH_2$$

CC 37-6 (Plastics Manufacture and Processing)
IT 839-88-3, Diallyl hydroxyethyl isocyanurate 1025-15-6, Triallyl isocyanurate 6294-79-7, Diallyl isocyanurate 13915-42-9

14748-81-3 20395-16-8, Diallyl epoxypropyl isocyanurate (interaction of, with glass fibers, model systems for determination of)

L43 ANSWER 20 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER:

1981:497857 HCAPLUS

DOCUMENT NUMBER:

95:97857

TITLE:

Cytostatic pharmaceutical compositions and

isocyanuric acid derivatives

INVENTOR(S):

Fischer, Herbert; Budnowski, Manfred; Zeidler,

Ulrich

PATENT ASSIGNEE(S):

Henkel K.-G.a.A., Fed. Rep. Ger.

SOURCE:

Ger. Offen., 43 pp. CODEN: GWXXBX

*

Patent

DOCUMENT TYPE: LANGUAGE:

German

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.		DATE		DATE
DE 3037004	7.1	10010416	DE 1000 3037004	10001001
	A1	19810416	DE 1980-3037094	
AT 7906552	A	19821215	AT 1979-6552	19791008
AT 371816	В	19830810		
NL 8005187	A	19810410	NL 1980-5187	
DK 8003953	A	19810409	DK 1980-3953	19800918
SE 8006716	A	19810409	SE 1980-6716	19800925
FI 8003108	A	19810409	FI 1980-3108	19800930
SU 976849	A3	19821123	SU 1980-2990883	19801003
GB 2060633	Α	19810507	GB 1980-32108	19801006
GB 2060633	В	19840321		
ZA 8006161	Α	19810930	ZA 1980-6161	19801006
DD 153370	A5	19820106	DD 1980-224376	19801006
CA 1159064	A1	19831220	CA 1980-361580	19801006
BE 885555	A1	19810407	BE 1980-202350	19801007
NO 8002977	A	19810409	NO 1980-2977	19801007
ES 495697	A1	19811216	ES 1980-495697	19801007
FR 2484418	A1	19811218	FR 1980-21417	19801007
FR 2484418	B1	19850906		
HU 24864	A2	19830428	HU 1980-2442	19801007
HU 182210	В	19831228		
PL 125862	B1	19830630	PL 1980-227131	19801007
US 4393060	A	19830712	US 1980-194908	19801007
CH 648554	A 5	19850329	CH 1980-7487	19801007
AU 8063063	Α	19810416	AU 1980-63063	19801008
AU 551079	B2	19860417		
JP 56061374	Α	19810526	JP 1980-141835	19801008

CA 1179266
PRIORITY APPLN. INFO.:

A2 19841211

CA 1983-435840 AT 1979-6552 19830831 A 19791008

CA 1980-361580

A3 19801006

OTHER SOURCE(S):

CASREACT 95:97857; MARPAT 95:97857

ED Entered STN: 12 May 1984

GI

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Diglycidylisocyanurates I (R = optionally substituted alkyl, aryl, cycloalkyl, heterocyclic; R1 = H, alkyl) were prepared Thus, triallylisocyanurate was epoxided to give I (R = allyl, R1 = H) and triglycidylisocyanurate, which was hydrolyzed to I [R = CH2CH(OH)CH2OH, R1 = H; II]. Three 50 mg/kg dodes of II i.p. increased the survival time of leukemia P388-infected mice to 226%.

THE CEASEST THE SULVIVAL CIME OF TEUREM
69731-45-9P 69804-58-6P 78627-41-5P
78627-42-6P 78627-44-8P 78627-46-0P
78627-47-1P 78627-48-2P 78627-49-3P
78627-50-6P 78627-51-7P 78639-55-1P

(preparation and antitumor activity of)

RN 69731-45-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(2-oxiranylmethyl)-5-(2-propen-1-yl)- (CA INDEX NAME)

$$\begin{array}{c|c}
CH_2-CH \longrightarrow CH_2\\
\hline
O & N & O\\
N & CH_2
\end{array}$$

$$\begin{array}{c|c}
CH_2-CH \longrightarrow CH_2\\
\hline
O & O\\
O & O\\$$

RN 69804-58-6 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-methyl-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c}
 & Me \\
 & N \\
 & N \\
 & N \\
 & O \\
 & O$$

RN 78627-41-5 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2,3-dihydroxypropyl)-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2 - \text{CH} - \text{CH}_2 - \text{OH} \\ \hline \\ & \text{O} \\ & \text{CH}_2 - \text{N} \\ & \text{O} \\ & \text{$$

RN 78627-42-6 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(3-chloro-2-hydroxypropyl)-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2\text{--}\text{CH}\text{--}\text{CH}_2\text{C1} \\ \hline \\ & \text{O} \\ & \text{N} \\ & \text{O} \\ & \text{$$

RN 78627-44-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[2-hydroxy-3-(4-morpholinyl)propyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & & & & \\ & & & \\ & &$$

RN 78627-46-0 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[2-hydroxy-3-[(2-hydroxyethyl)thio]propyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} \text{OH} & \text{OH} \\ \text{CH}_2-\text{CH}-\text{CH}_2-\text{S}-\text{CH}_2-\text{CH}_2-\text{OH} \\ \\ \text{O} & \text{N} & \text{O} \\ \\ \text{O} & \text{CH}_2-\text{N} & \text{N} & \text{CH}_2 \\ \\ \end{array}$$

RN 78627-47-1 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[2-hydroxy-3-(1-oxopropoxy)propyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} \text{OH} & \text{O} \\ | & \text{CH}_2 - \text{CH} - \text{CH}_2 - \text{O} - \text{C} - \text{Et} \\ | & \text{O} \\ | & \text{N} & \text{O} \\ | & \text{CH}_2 - \text{N} & \text{N} - \text{CH}_2 \end{array}$$

RN 78627-48-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-hydroxy-3-propoxypropyl)-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2\text{--}\text{CH}-\text{CH}_2\text{--}\text{OPr-n} \\ \hline \\ & \text{O} \\ & \text{CH}_2\text{---} \\ & \text{N} \\ & \text{O} \\ & \text{O} \\ \end{array}$$

RN 78627-49-3 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-hydroxypropyl)-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} \text{OH} & \\ \text{CH}_2-\text{CH}-\text{Me} \\ \\ \vdots & \\ \text{O} & \\ \text{N} & \\ \text{O} & \\$$

RN 78627-50-6 HCAPLUS
CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[3-[(2,3-dihydroxypropyl)thio]-2-hydroxypropyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} \text{OH} & \text{OH} \\ \text{CH}_2-\text{CH}-\text{CH}_2-\text{S}-\text{CH}_2-\text{CH}-\text{CH}_2-\text{OH} \\ \\ \text{O} & \text{N} & \text{O} \\ \\ \text{O} & \text{CH}_2 & \text{N} & \text{N} & \text{CH}_2 \\ \\ \text{O} & \text{O} & \text{O} \\ \end{array}$$

RN 78627-51-7 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[2-hydroxy-3-(octylthio)propyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2\text{-}\text{CH-}\text{CH}_2\text{-}\text{s-}\text{(CH}_2)_7\text{-}\text{Me} \\ \\ & \text{O} \\ & \text{N} \\ & \text{O} \\ & \text{CH}_2\text{-}\text{N} \\ & \text{O} \\ & \text{O} \end{array}$$

RN 78639-55-1 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[3-(diethylamino)-2-hydroxypropyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2-\text{CH}-\text{CH}_2-\text{NEt}_2 \\ \hline \\ \text{O} & \text{N} & \text{O} \\ \hline \\ \text{O} & \text{CH}_2-\text{N} & \text{N}-\text{CH}_2 \\ \hline \\ \text{O} & \text{O} \\ \end{array}$$

IT 2451-62-9P

(preparation and hydrolysis of)

RN 2451-62-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3,5-tris(2-oxiranylmethyl)-(CA INDEX NAME)

IT 53866-66-3P 53866-69-6P 78627-43-7P 78627-45-9P 78627-52-8P 78627-53-9P

(preparation of)

RN 53866-66-3 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(3-chloro-2-hydroxypropyl)-5-(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & \text{OH} \\ & \text{CH}_2-\text{CH}-\text{CH}_2\text{Cl} \\ \\ \hline \\ \text{O} \\ & \text{CH}_2-\text{N} \\ \\ \text{O} \\ & \text{CH}_2-\text{CH}-\text{CH}_2\text{Cl} \\ \\ \\ \text{O} \\ \end{array}$$

RN 53866-69-6 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis(2,3-dihydroxypropyl)-5-(oxiranylmethyl)- (9CI) (CA INDEX NAME)

RN 78627-43-7 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis[3-(diethylamino)-2-hydroxypropyl]-5-(oxiranylmethyl)- (9CI) (CA INDEX NAME)

RN 78627-45-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1,3-bis[2-hydroxy-3-(4-morpholinyl)propyl]-5-(oxiranylmethyl)- (9CI) (CA INDEX NAME)

RN 78627-52-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[3-(2-benzothiazolylthio)-2-hydroxypropyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & & & & \\ & & & \\ & &$$

RN 78627-53-9 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-[3-(1H-benzimidazol-2-ylthio)-2-hydroxypropyl]-3,5-bis(oxiranylmethyl)- (9CI) (CA INDEX NAME)

$$\begin{array}{c|c} & & & & \\ & & & \\ & &$$

IT 6726-47-2

(reaction of, with epichlorohydrin)

RN 6726-47-2 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-methyl- (9CI) (CA INDEX NAME)

IC C07D405-06; C07D251-32; C07D413-06; A61K031-53

CC 28-21 (Heterocyclic Compounds (More Than One Hetero Atom))

IT 69731-45-9P 69804-58-6P 78627-41-5P

78627-42-6P 78627-44-8P 78627-46-0P

78627-47-1P 78627-48-2P 78627-49-3P

78627-50-6P 78627-51-7P 78639-55-1P

(preparation and antitumor activity of)

IT 2451-62-9P

(preparation and hydrolysis of)

IT 53866-66-3P 53866-69-6P 78627-43-7P

78627-45-9P 78627-52-8P 78627-53-9P

(preparation of)

IT 108-80-5 6726-47-2

(reaction of, with epichlorohydrin)

L43 ANSWER 21 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1974:536892 HCAPLUS

DOCUMENT NUMBER: 81:136892

TITLE: Dependence of the physicomechanical properties of

glass fiber-reinforced polyester plastics on the

surface treatment of the glass fiber

AUTHOR(S): Abraimova, V. P.; Novikova, O. A.; Shevlyakov, A.

s.

CORPORATE SOURCE: Inst. Khim. Vysokomol. Soedin., Kiev, USSR

SOURCE: Sintez i Fiziko-Khimiya Polimerov (1974), 13,

150-3

CODEN: SFKPAO; ISSN: 0583-4317

DOCUMENT TYPE: Journal LANGUAGE: Russian

ED Entered STN: 12 May 1984

AB Surface treatment of glass fibers, used as reinforcement for polyester resins, with diallyl hydroxyethyl isocyanurate (I) [839-88-3], diallyl epoxypropyl isocyanurate (II) [20395-16-8], diallyl carboxymethyl isocyanurate (III) [13915-42-9] and diallyl hydroxybutyl isocyanurate (IV) [52794-84-0] was examined in fibers containing I and II as lubricants showed increased phys. mech. and elec. properties, compared to those treated with paraffin emulsions. I and II increased the resistance to water and cross-breaking strength of fibers, due to their solubility in water and softening of the fiber surface. They polymerize by themselves and contained allyl group which interacted with double bonds in unsatd. compds., forming a strong bond between the resins and glass fiber surface. The crystalline III had good adhesion properties but the lubricant film was rigid, brittle and decomposed on processing, whereas IV was unstable in storage, and the strength of fibers containing it decreased significantly on exposure to water. Mech. properties of plastics containing lubricants were directly dependent on their water absorption.

IT 13915-42-9 20395-16-8

(lubricants, for glass fiber, mech. and elec. properties of reinforced plastics in presence of)

RN 13915-42-9 HCAPLUS

CN 1,3,5-Triazine-1(2H)-acetic acid, tetrahydro-2,4,6-trioxo-3,5-di-2-propenyl- (9CI) (CA INDEX NAME)

RN 20395-16-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-oxiranylmethyl)-3,5-di-2-propen-1-yl- (CA INDEX NAME)

$$CH_2-CH = CH_2$$
 O
 N
 O
 $CH_2-CH = CH_2$
 O
 $CH_2-CH = CH_2$

CC 36-6 (Plastics Manufacture and Processing) IT 839-88-3 13915-42-9 20395-16-8 52794-84-0

(lubricants, for glass fiber, mech. and elec. properties of reinforced plastics in presence of)

L43 ANSWER 22 OF 22 HCAPLUS COPYRIGHT 2007 ACS on STN

ACCESSION NUMBER: 1974:71501 HCAPLUS

DOCUMENT NUMBER: 80:71501

TITLE: Evaluation of the effectiveness of potential

finishing agents-lubricants

AUTHOR(S): Fainerman, A. E.; Lipatov, Yu. S.; Novikova, O.

A.; Samoilenko, M. I.; Ivanova, G. V.

CORPORATE SOURCE: USSR

SOURCE: Plasticheskie Massy (1973), (9), 38-40

CODEN: PLMSAI; ISSN: 0554-2901

DOCUMENT TYPE: Journal Russian

ED Entered STN: 12 May 1984

The effectiveness of 14 lubricants and finishing agents for glass reinforced plastic, such as diallyl isocyanurate (I) [6294-79-7] and 12 alkyl derivs. such as hydroxyethyl diallyl isocyanurate (II) [839-88-3], 3-hydroxypropyl diallyl isocyanurate (III) [50978-73-9], or 4-hydroxybutyl diallyl isocyanurate (IV) [43193-30-2] was evaluated from surface tension data. The surface tension steadily decreased in the order II > III > IV. The phys. mech. properties of glass reinforced plastics modified with I derivs. were determined

IT 13915-42-9 20395-16-8

(lubricants, for glass fiber-reinforced plastics)

RN 13915-42-9 HCAPLUS

CN 1,3,5-Triazine-1(2H)-acetic acid, tetrahydro-2,4,6-trioxo-3,5-di-2-propenyl- (9CI) (CA INDEX NAME)

RN 20395-16-8 HCAPLUS

CN 1,3,5-Triazine-2,4,6(1H,3H,5H)-trione, 1-(2-oxiranylmethyl)-3,5-di-2-propen-1-yl- (CA INDEX NAME)

$$\begin{array}{c|c} \text{CH}_2\text{--}\text{CH} & \text{CH}_2\\ \hline \\ \text{O} & \text{N} & \text{O}\\ \hline \\ \text{CH}_2\text{---}\text{N} & \text{N}\\ \hline \\ \text{O} & \text{CH}_2\text{---}\text{CH} & \text{CH}_2\\ \hline \end{array}$$

CC 36-6 (Plastics Manufacture and Processing)
IT 839-88-3 6294-79-7 13915-41-8 13915-42-9
20395-16-8 40254-50-0 43193-30-2 43193-32-4 43193-33-5
43193-34-6 50978-73-9 51348-03-9
(lubricants, for glass fiber-reinforced plastics)

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              2 SEA ABB=ON PLU=ON JP2002-295777/PRN, AP, PN
L2
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L3
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                681440-25-5/BI OR 9002-88-4/BI)
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L10
             13 SEA SUB=L4 SSS SAM L9
                STR L9
L11
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L12
           1699 SEA SUB=L4 SSS FUL L11
L13
             14 SEA ABB=ON PLU=ON L13 AND L3
L14
L15
              5 SEA ABB=ON PLU=ON L3 NOT L14
                SAV L13 LEE349/A
L16
                STR L7
L17
              0 SEA SUB=L13 SSS SAM L16
L18
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L19
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L20
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L21
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L22
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L23
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L24
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L25
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L26
L27
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L28
              0 SEA SUB=L13 SSS SAM L25
L29
                STR L25
             50 SEA SUB=L4 SSS SAM L29
L30
L31
                STR L29
              0 SEA SUB=L13 SSS SAM L31
L32
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L33
L34
             27 SEA SUB=L33 SSS SAM L31
L35
            457 SEA SUB=L33 SSS FUL L31
                SAV L35 LEE349D/A
L36
              O SEA ABB=ON PLU=ON L21 AND L24 AND L35
     FILE 'HCAPLUS' ENTERED AT 08:05:05 ON 15 AUG 2007
L37
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L38
            214 SEA ABB=ON PLU=ON
           2081 SEA ABB=ON PLU=ON L21
L39
```

•	L40	1	SEA	ABB=ON	PLU=ON	L37 AND	L38 AND	L39
	L41	12	SEA	ABB=ON	PLU=ON	L39 AND	L38	
	L42	11	SEA	ABB=ON	PLU=ON	L39 AND	L37	
	L43	22	SEA	ABB=ON	PLU=ON	(L41 OR	L42)	